

Webinar Series in TEM: Transmission Electron Microscopy - Part 1

A Brief Introduction to TEM

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LabTEM
HIGH RESOLUTION

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HT	Size	Dwell	Coll. Angle	1 nm
80 kV	2048	10.0 μ s	9 - 36 mrad	iDPC

Transmission Electron Microscopy Webinar Series

Outline: Part 01

- Basic Theory of TEM
- SEM vs. TEM: What are the differences
- Conventional TEM Imaging
 - Bright-Field Imaging
 - Dark-Field Imaging
- Electron Diffraction
 - Selective Area Electron Diffraction
 - Convergence Beam Electron Diffraction
 - Nano Beam Electron Diffraction
- Advanced TEM Imaging
 - High-resolution TEM
- Special Investigation Cases
 - Magnetic Samples
 - Soft Materials
 - In-situ Investigations
 - Life-Sciences

Transmission Electron Microscopy Webinar Series

Outline: Part 02

- An Overview of TEM Sample Preparation
- Various Types of TEM Sample Preparations
 - Conventional Techniques
 - Focus Ion Beam Techniques
- Practical Aspects of TEM Sample Preparations

Transmission Electron Microscopy Webinar Series

Outline: Part 03

- Scanning Transmission Electron Microscopy (STEM)
- TEM and STEM comparisons
- High-resolution Scanning TEM (HRSTEM)
- Spectroscopy in TEM
 - Energy-Dispersive X-Rays Spectroscopy
 - Electron Energy Loss Spectroscopy
- Tomography in TEM: For 2D to 3D Imaging

Transmission Electron Microscopy Webinar Series

Outline: Part 04

- An Overview of TEM for Biological Materials Research
- Biological Samples Preparations
- Room Temperature Investigations
- Cryo-EM Workflow

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(A simplify) Basic Theory of TEM

Electron Microscopy History

- 1897: Thompson describes the existence of negatively charged particles (electrons)
- 1925: De Broglie theorized that electrons have wave-like characteristics, addressing the wave/particle duality
- 1927: Thompson and Reid demonstrated the wave nature of electrons by diffraction experiments
- 1931: Ruska et al. build the first electron microscope (Nobel Prize in 1986)

Knoll and Ruska (in the lab coat) with the first Transmission Electron Microscope in Berlin in the early 1930s

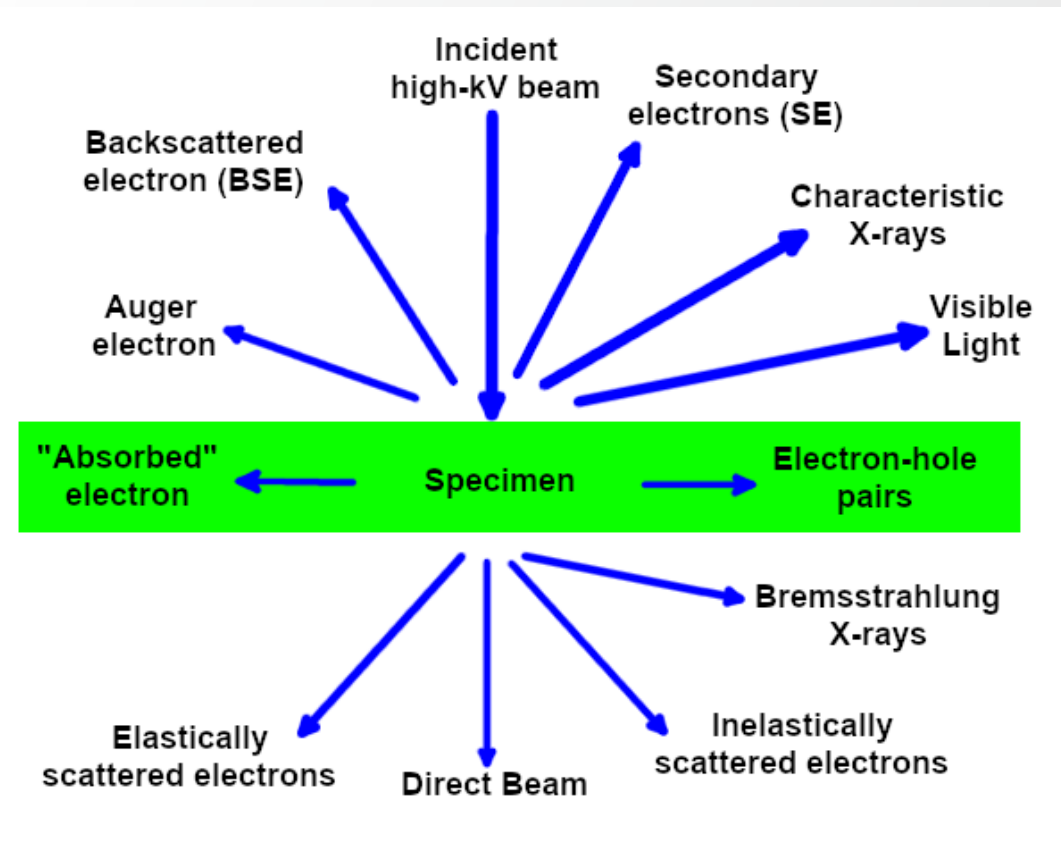


(A simplify) Basic Theory of TEM

What is TEM?



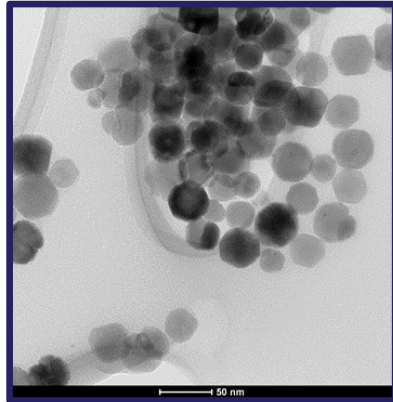
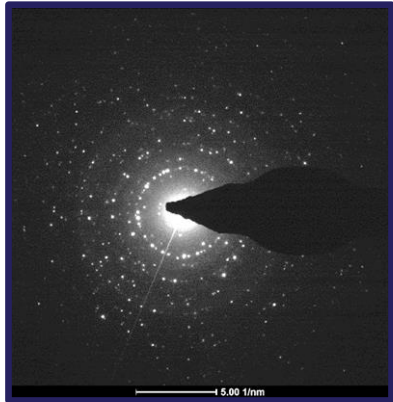
- To see **small objects** which cannot be seen with naked eyes, light microscope or even a SEM.
- To obtain structural information of **small objects**
- To analyze the chemical compositions of **small objects**



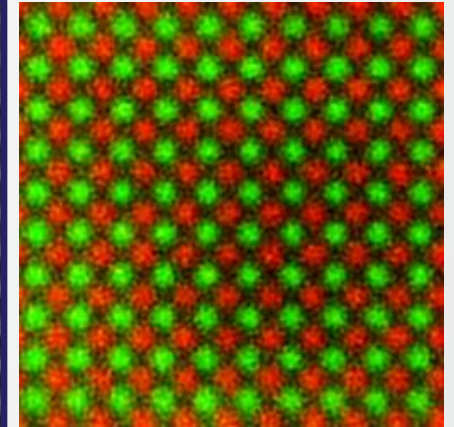
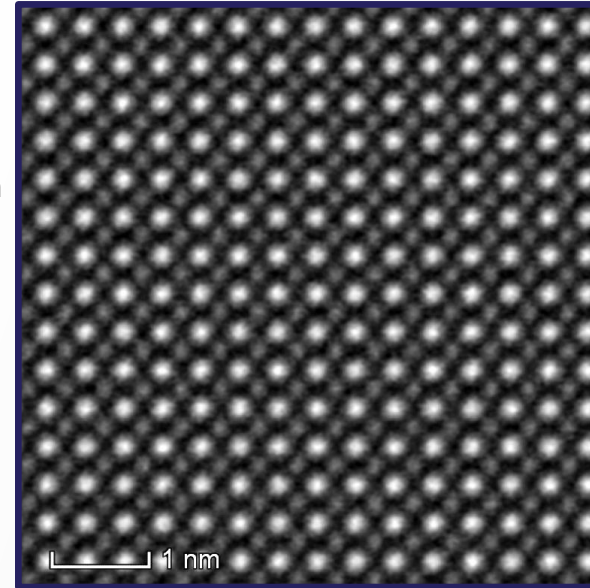
Electron – Sample Interactions

(A simplify) Basic Theory of TEM

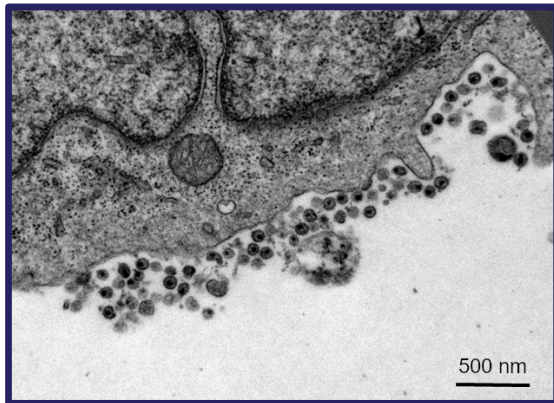
What can TEM Do?



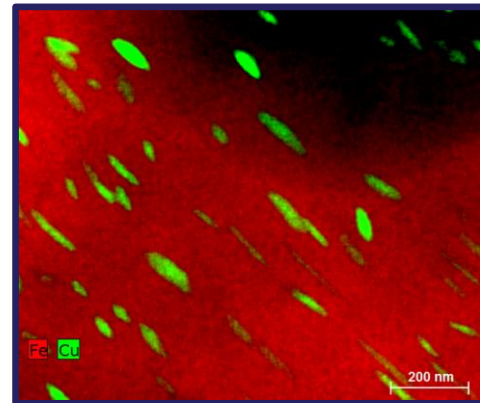
Electron Diffraction pattern (SAED) taken from nano particles (left) as shown in TEM-BF (right)



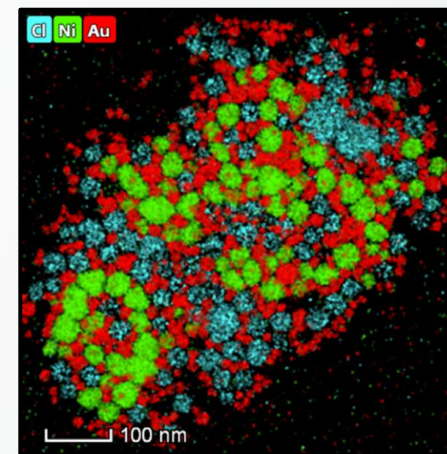
HRSTEM and HREDS SrTiO₃



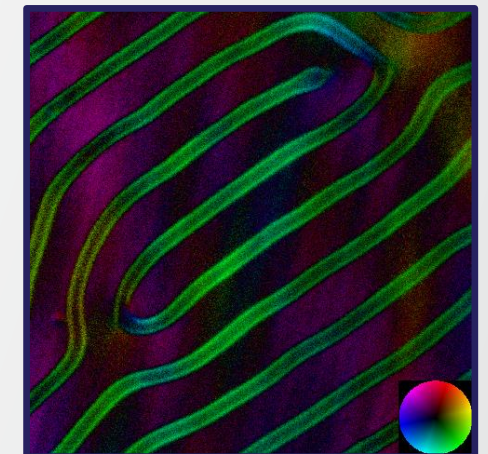
Cat bone marrow with Feline Immunodeficiency Virus



EDX mapping of Cu and Fe elements distribution in steel



Au-Ni-Cl nanoparticles

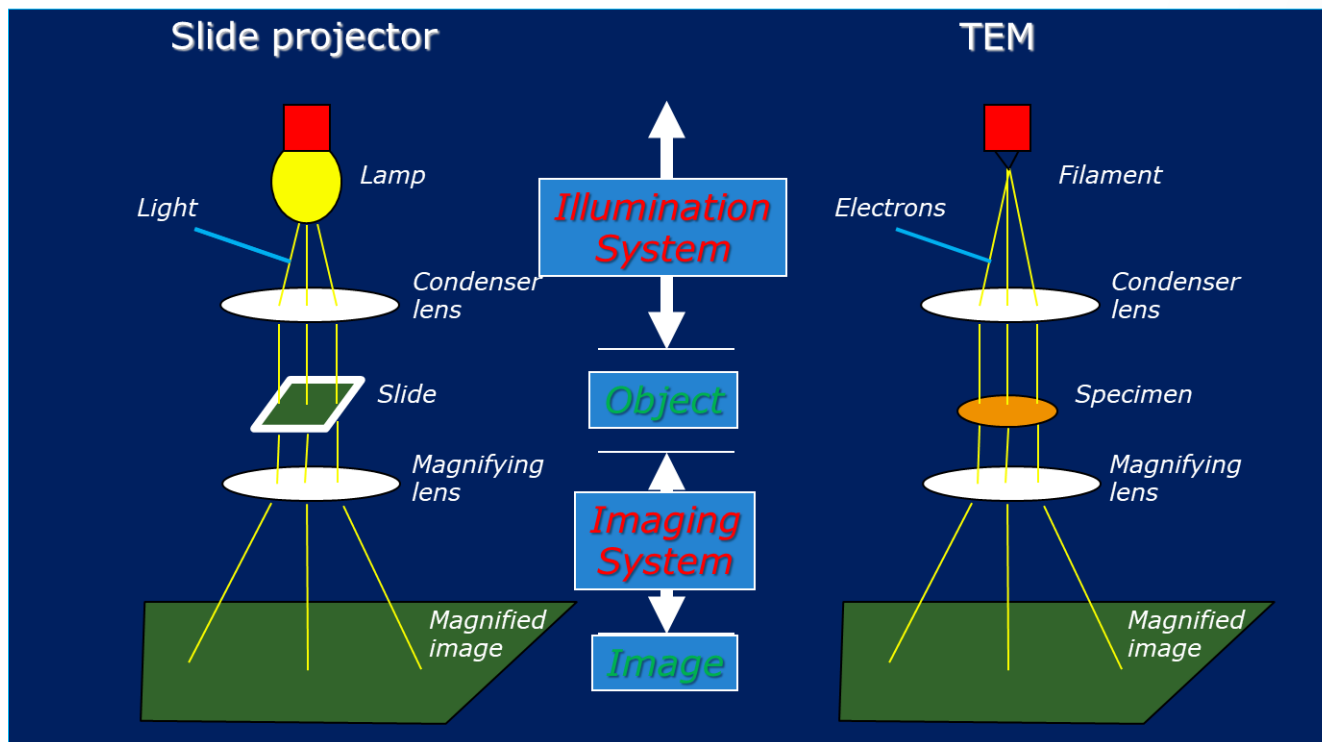


Magnetic Hexa-ferrite

(A simplify) Basic Theory of TEM

How does TEM Work?

Slide Projector vs TEM

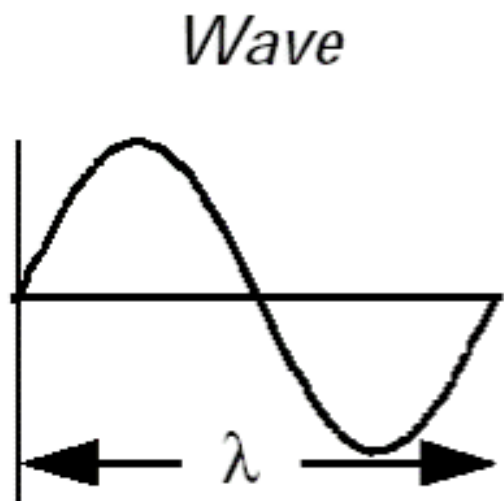


Light Microscope	Transmission Electron Microscope
Visible light	electron
Glass lenses	Electron-magnetic lenses
$\lambda = 450-650 \text{ nm}$	$\lambda = 0.0025 \text{ nm (200 kV)}$
spatial resolution = 100 nm ($d > \lambda$)	spatial resolution = 0.24 nm ($d \cong \lambda$)

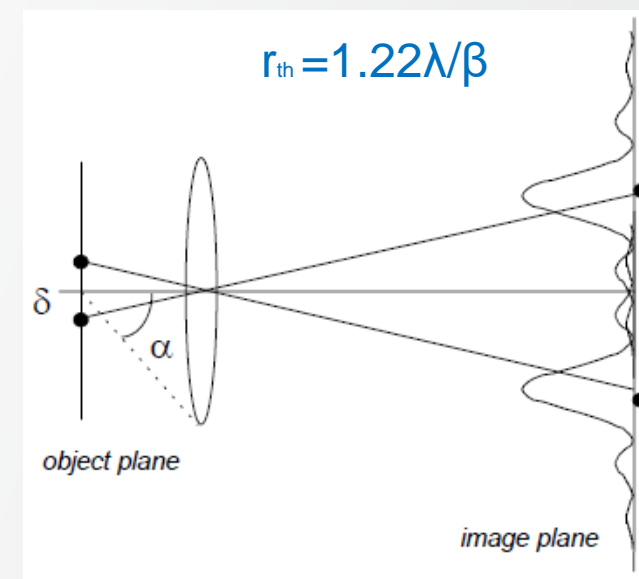
(A simplify) Basic Theory of TEM

Why Use Electrons?

- The resolution of light microscopy is limited by the wavelength of visible light (400 – 700nm)*
- Electrons, that are **particles** as well as a **wave**, have much shorter wavelength, which gives much better resolution
- De Broglie equation: $\lambda = h/mv$



U (kV)	Relativistic (λ=nm)
100	0.0037
120	0.0034
200	0.0025
300	0.0020

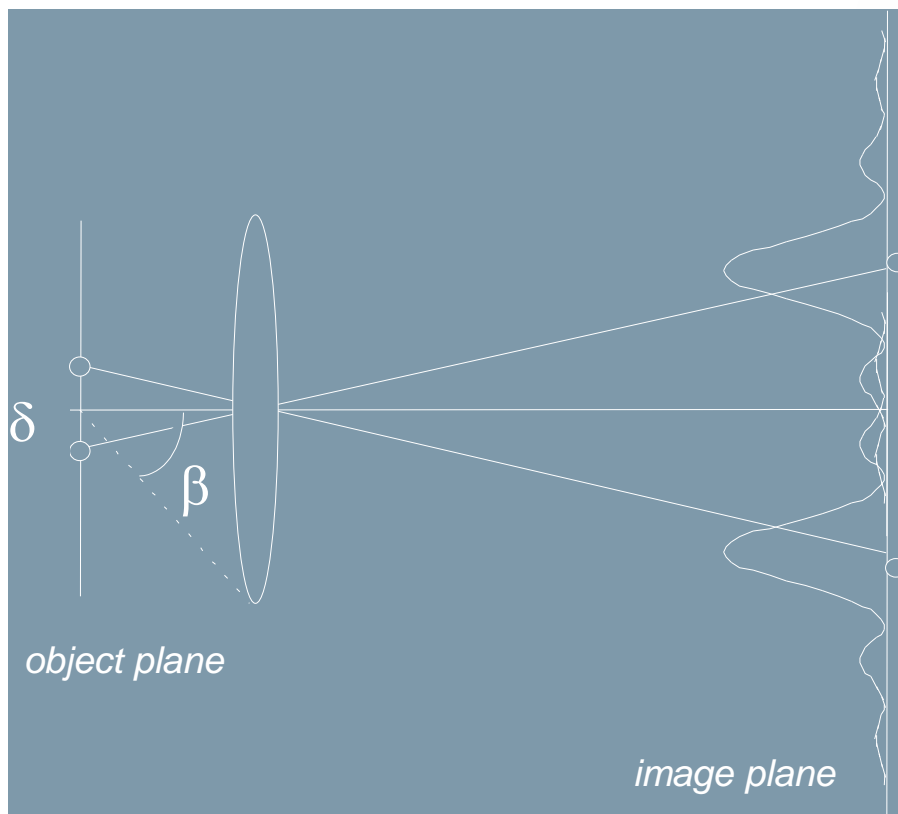


*X-ray wavelength is about 0.05-0.25 nm

(A simplify) Basic Theory of TEM

Resolution

- Resolution (or Resolving Power): the smallest distance between two points that can be resolved



Rayleigh Criterion:

$$\delta = \frac{0.61\lambda}{n \sin \beta}$$

Light microscopy:

$n=1.5$ (oil)

$\lambda=400$ nm

$\beta=60^\circ$

$d=200$ nm

(A simplify) Basic Theory of TEM

Magnification vs. Resolution

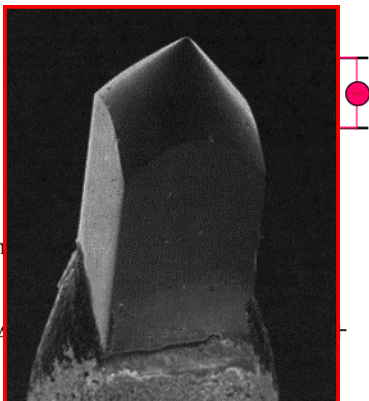
Resolution is more critical than magnification



(A simplify) Basic Theory of TEM

Electron Sources

Thermionic



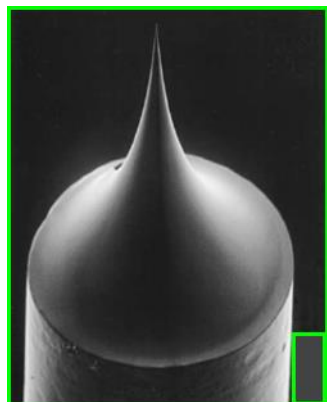
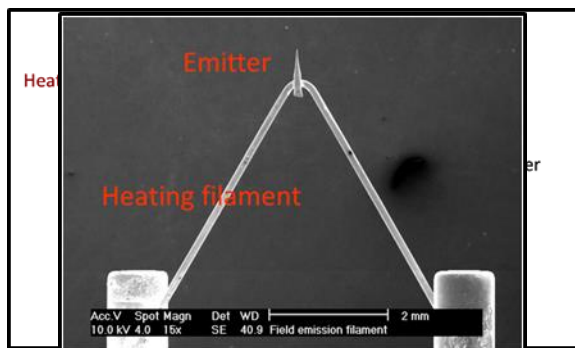
	LaB ₆	SFEG	XFEG	X-CFEG
Normalized brightness	1-3	250	1250	1625
Energy spread (eV)	1.1-1.5	≤0.8	≤ 0.8	≤ 0.3

Tungsten(W)/LaB₆ → SFEG → XFEG → X-CFEG



Better Performance

Field Emission Gun (FEG)

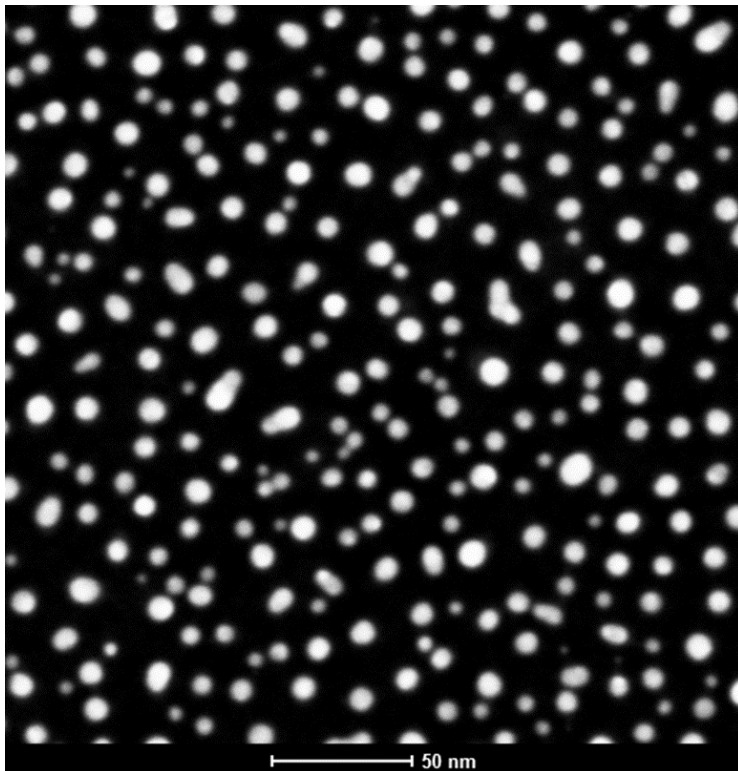


(A simplify) Basic Theory of TEM

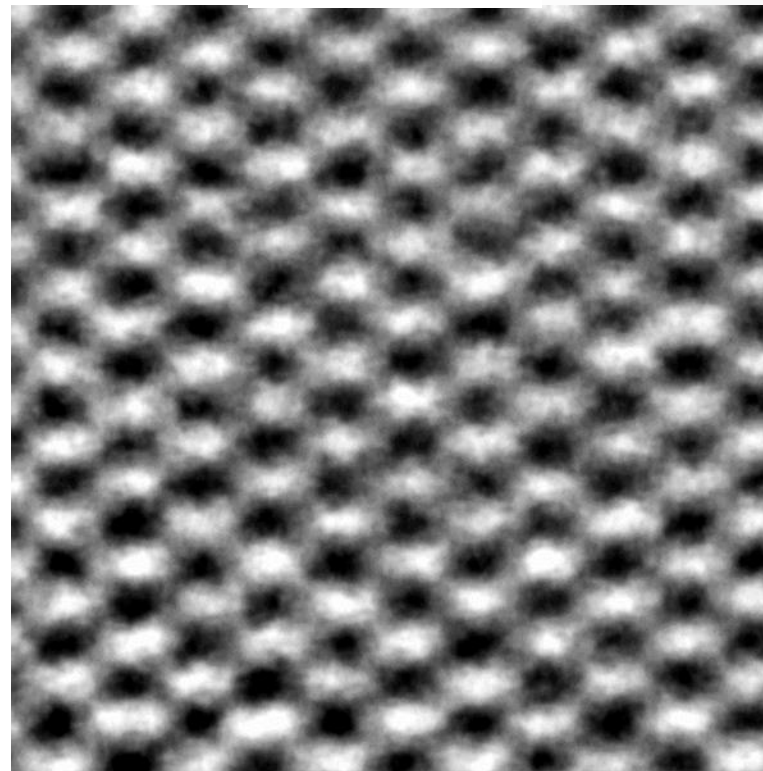
Spatial Resolution in High-resolution Imaging

HR-STEM image taken from different TEM with different probe size

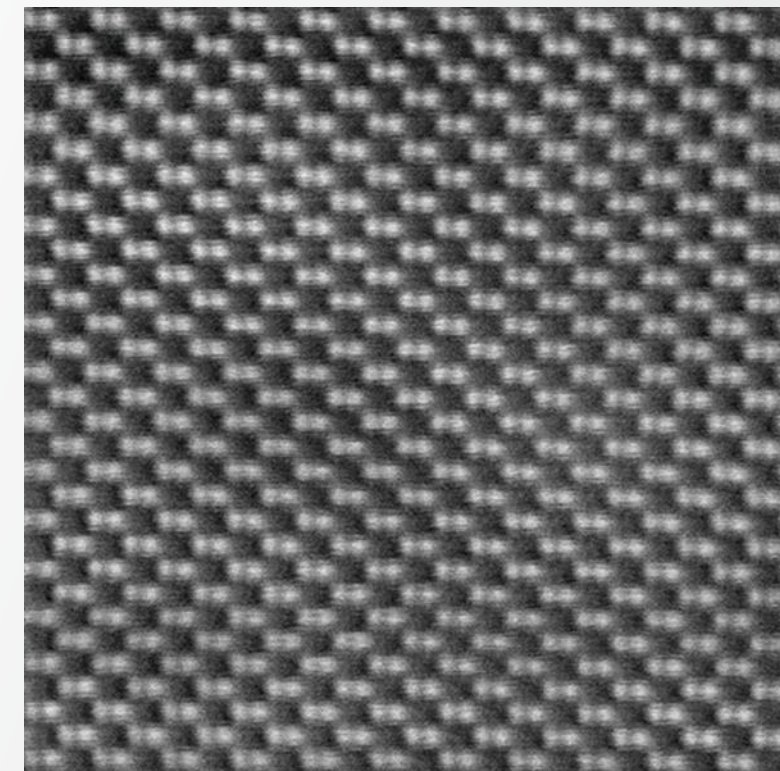
Probe size <<<



Maximum Magnification
Au nano particle @ 120 kV
STEM resolution ≤ 1 nm



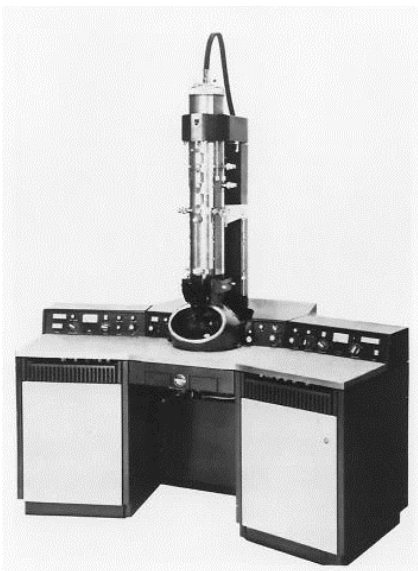
Highest Magnification
The Si <110> dumbbells are
seen as one atom @200kV



Better spatial resolution
The dumbbells are clearly
resolved to be separated

(A simplify) Basic Theory of TEM

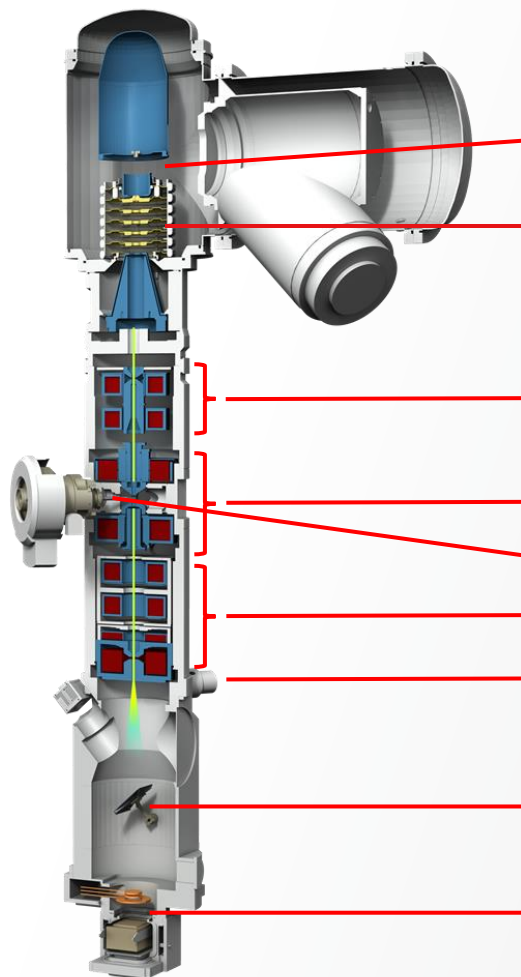
Parts of the TEM



Philips Eindhoven
1966



Talos F200X



EELS

Electron Gun – LaB6, FEG, XFEG
(CFEG, X-CFEG, monochromator)

Produces electrons

Accelerator (200 kV)

Accelerates the electrons
to high energy

Condenser lens

Control illumination on
the sample

Condenser aperture

Objective lens

Sample and main imaging
lens + EDS (objective lens)

Sample / Holder / EDS detectors

Diffraction and Projection lens (magnification)

Controls magnification
and image/diffraction
mode

STEM detectors: HAADF, 4DSTEM
Detectors for imaging formation

Flu-Screen

Flu-screen image viewed
using a camera + monitor

TEM camera

STEM detectors (BF/DF)

TEM and STEM detectors

All in high vacuum

Whole column under high vacuum

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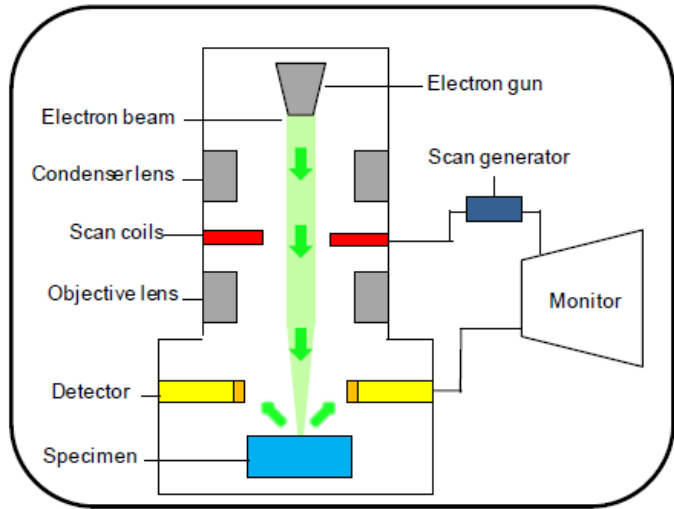
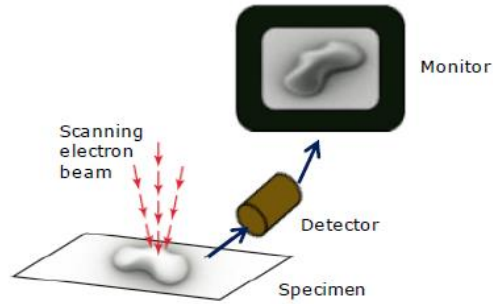
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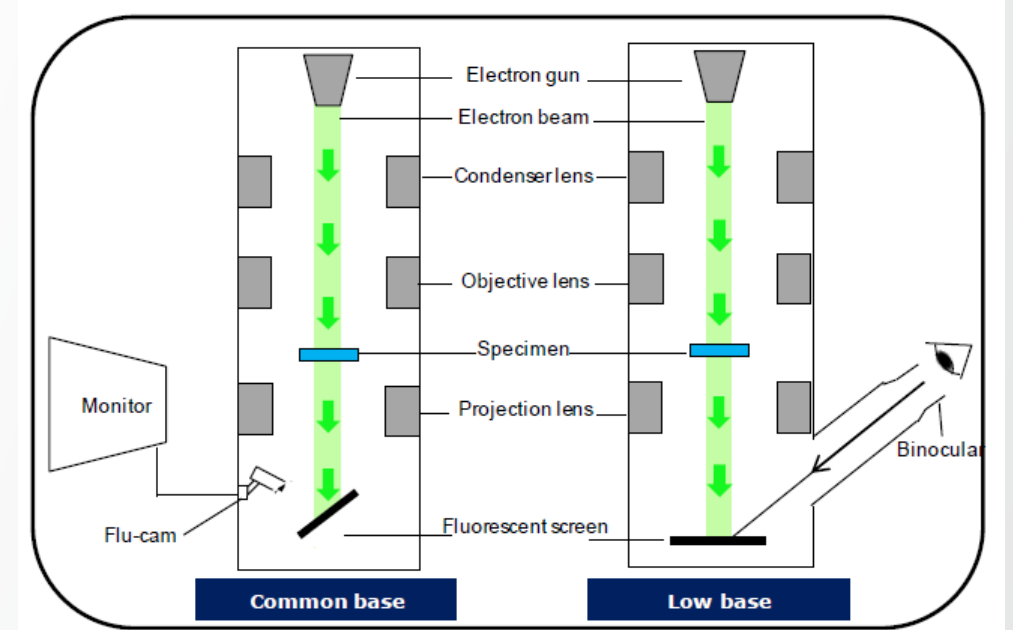
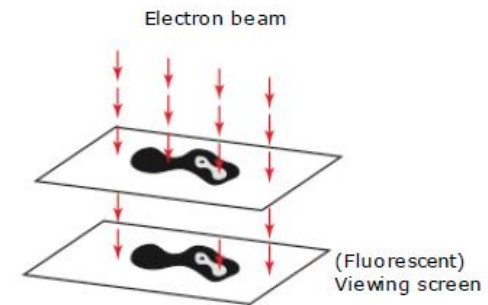
SEM vs TEM

What are the differences?

SEM: Scanning Electron Microscope



TEM: Transmission Electron Microscope

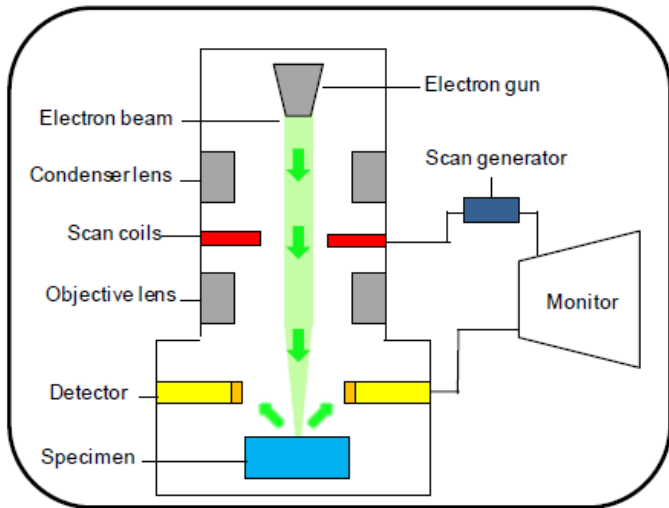


SEM vs TEM

What are the differences?

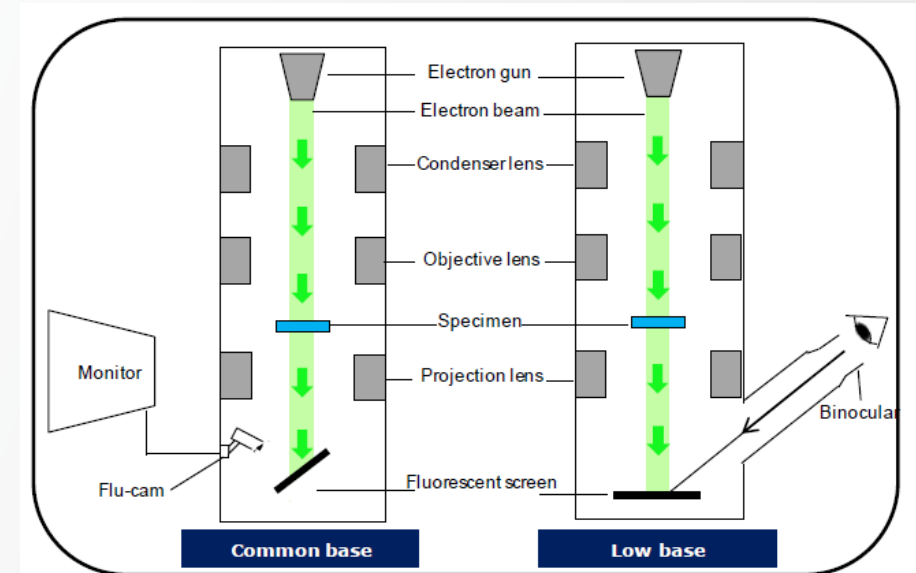
SEM: Scanning Electron Microscope

- Smaller/shorter
- Acceleration voltage: 5kV – 30 kV
- Resolution ≥ 0.7 nm
- Focused scanning beam
- Larger specimen chamber
- Larger samples



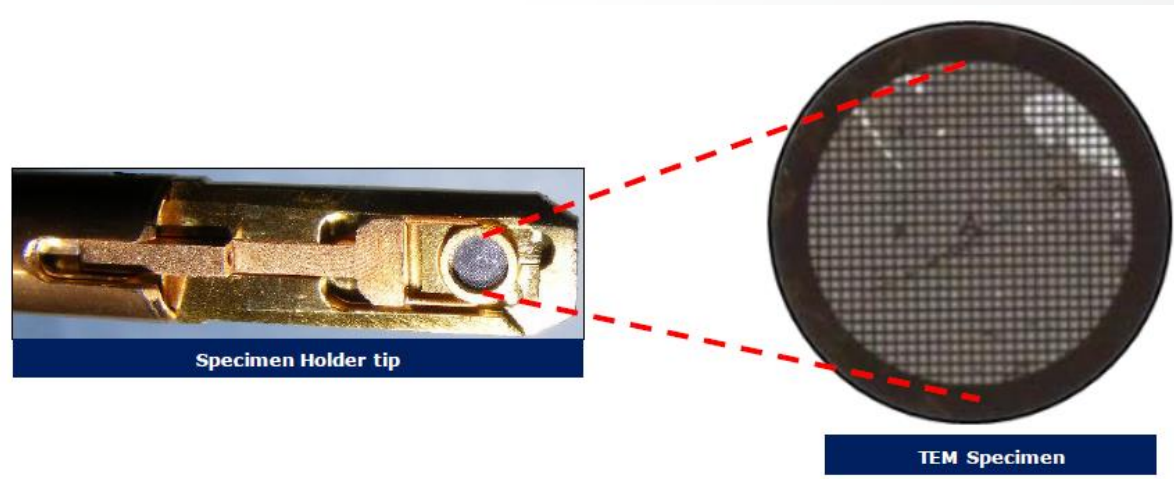
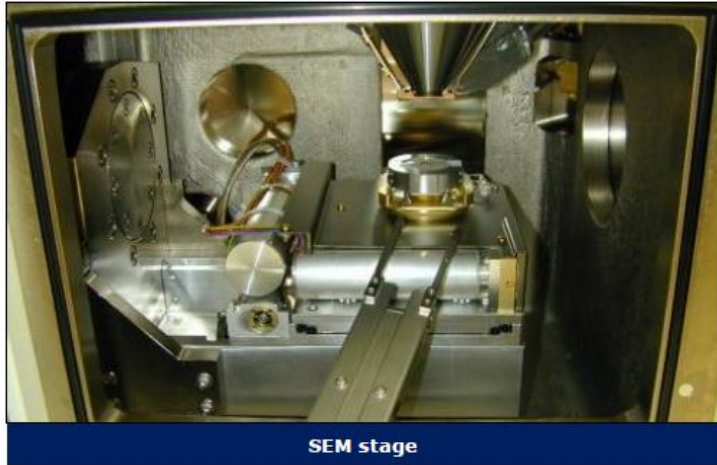
Transmission Electron Microscope

- Larger/taller
- Acceleration voltage: 60-300kV or 30kV – 1MV*
- Resolution ≤ 0.1 nm
- Broad static beam and *focused scanning beam (STEM)**
- Smaller specimen chamber
- Thin samples of ≈ 100 nm



SEM vs TEM

Samples



- Diameter: 2-3 mm
- Thickness: 100 – 150 nm

SEM vs TEM

What is their differences?

- SEM
 - Controlling the electrons to scan the sample surface: Scanning Electron Microscope (SEM)
 - Bulk sample, chamber constrain the sample's size and dimension
 - Sample preparation: "Relatively" simple and straight forward
 - Operating Voltage: 5 – 30 keV
 - Most detectors are located above the sample
 - Resolution achieved ≥ 0.7 nm
 - Capable to produce 2D imaging
- TEM
 - Transmitted electrons through the sample: Transmission Electron Microscope (TEM)
 - The sample must be very thin: Electron transparent sample (≈ 50 nm)
 - Sample preparation: More complicated than SEM
 - Operating Voltage: 30 – 300 kV - (1000 kV)*
 - Most detectors are located below the sample
 - Resolution achieved ≤ 0.1 nm
 - Capable to produce 2D and 3D imaging

*) The 1000 kV, known as HVTEM, was very popular to achieve a high resolution. But nowadays with the help or aberration-corrected microscope the high-resolution image can be acquired with much lower operating voltage.

SEM vs TEM

What is their differences?

- SEM
 - Typical imaging techniques available:
 - Secondary Electron (SE) Imaging: Surface Morphology
 - Back Scattering Electron(BSE) Imaging: Sample Composition
 - Scanning Transmission (ST) Imaging*: Sample Composition
 - Electron Back Scattering Diffraction (EBSD): Crystallography
 - Energy Dispersive Spectroscopy (EDS), Wavelength Dispersive Spectroscopy (WDS): Element Mapping
- TEM
 - Typical imaging techniques available:
 - Bright-Field (BF) and Dark-Field (DF) Imaging: Morphology, Grain orientation
 - Electron Diffraction: Crystallography Structure Information
 - High Angle Angular Dark Field Image (HAADF): Z-Contrast/Chemical Contrast Image

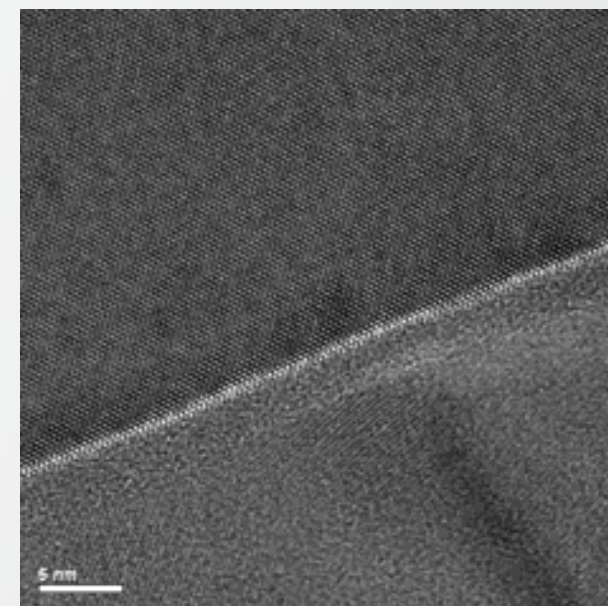
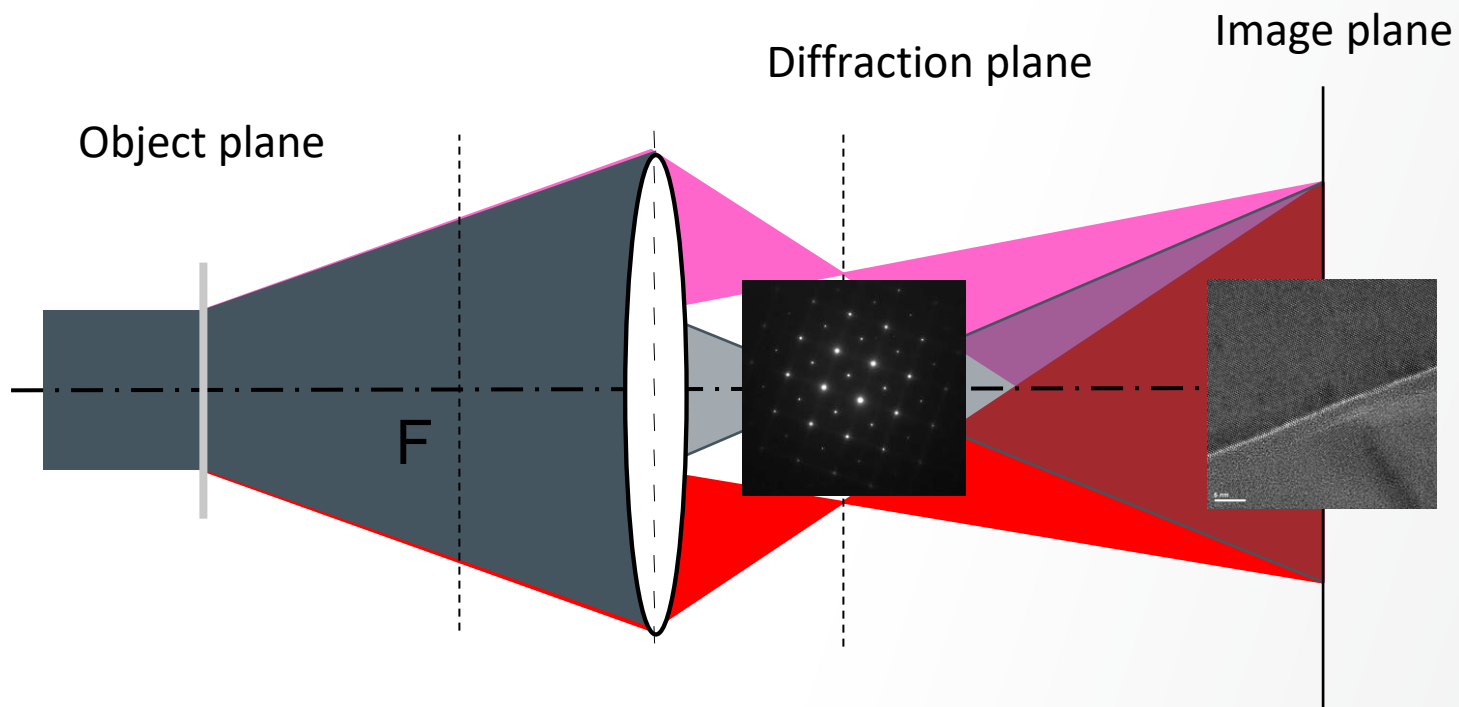
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Conventional TEM Imaging

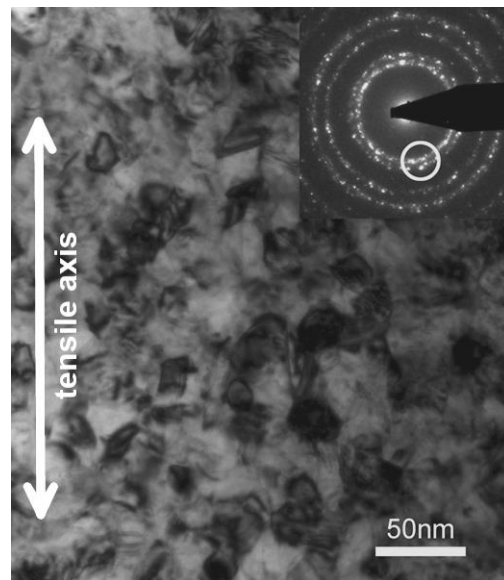
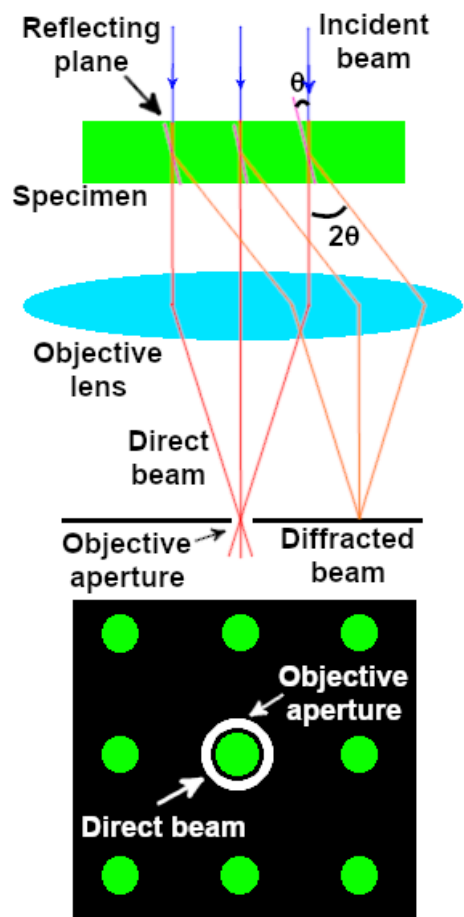
Optics: Image and Diffraction Formation



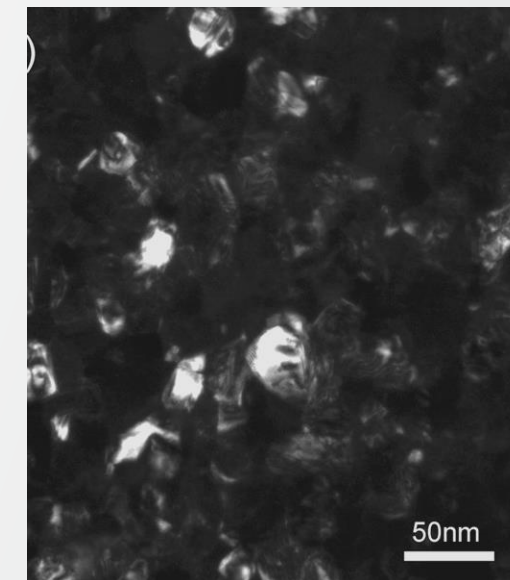
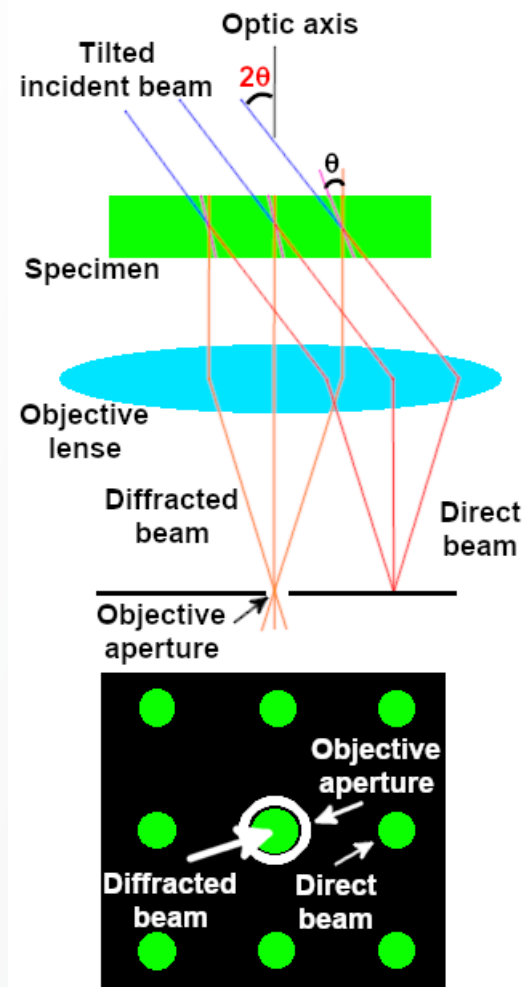
Conventional TEM Imaging

Bright and Dark Field Imaging

Bright and Dark Field (BF and DF) images of plan-view FIB sample prepared from a 310 nm thick Pd film deformed at 4%.



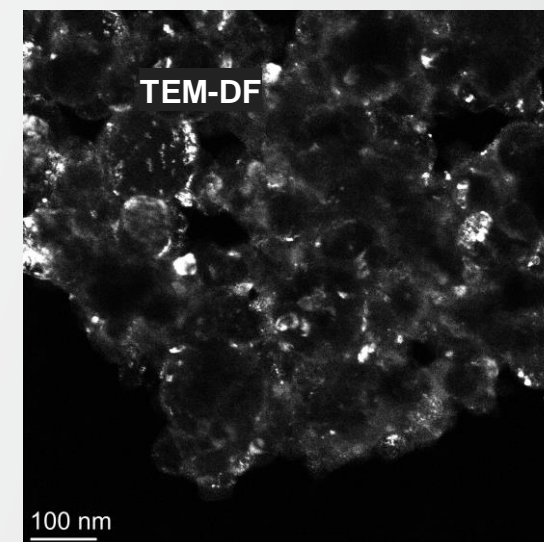
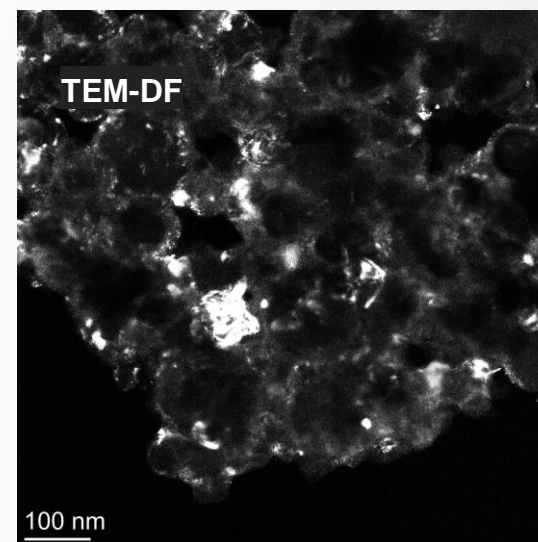
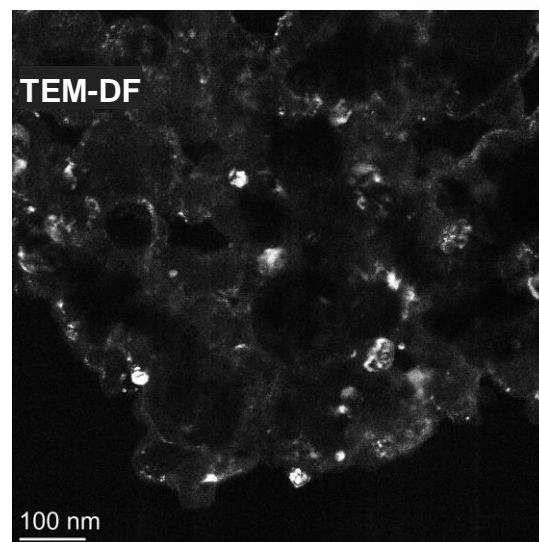
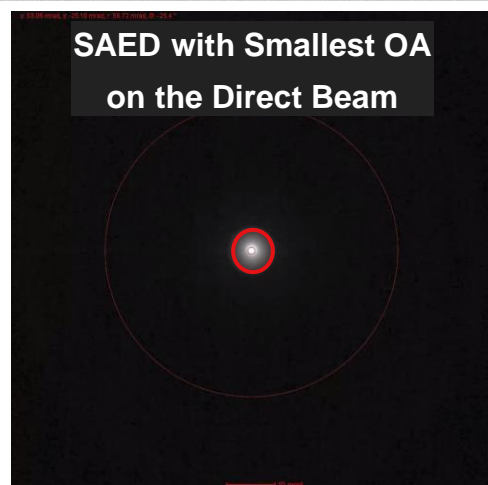
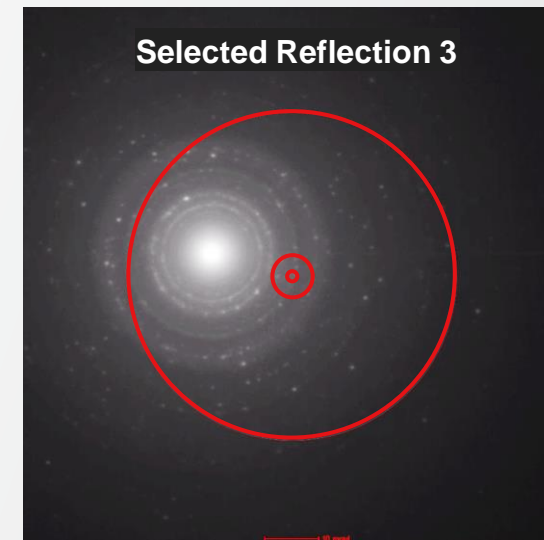
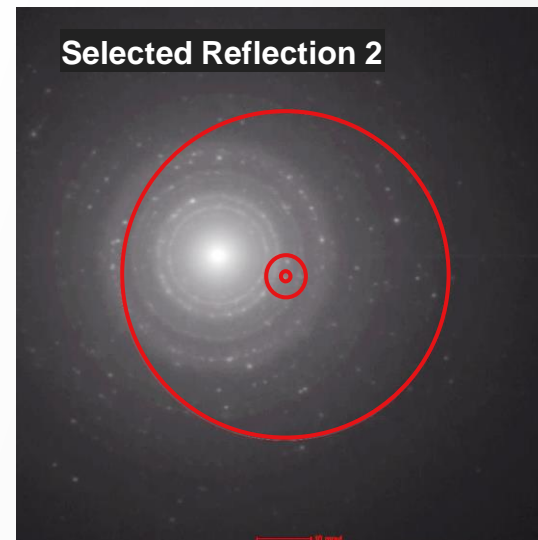
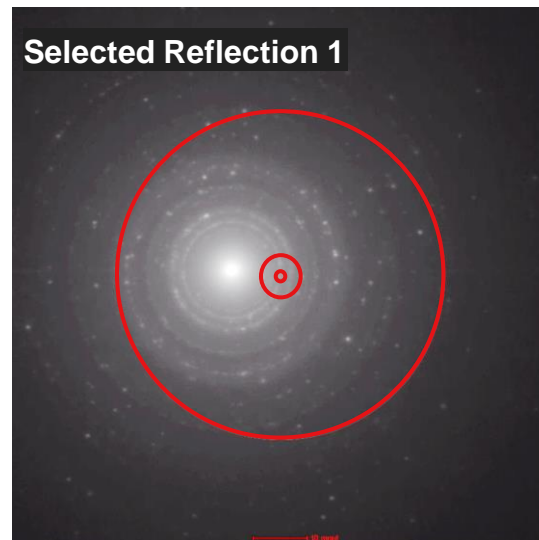
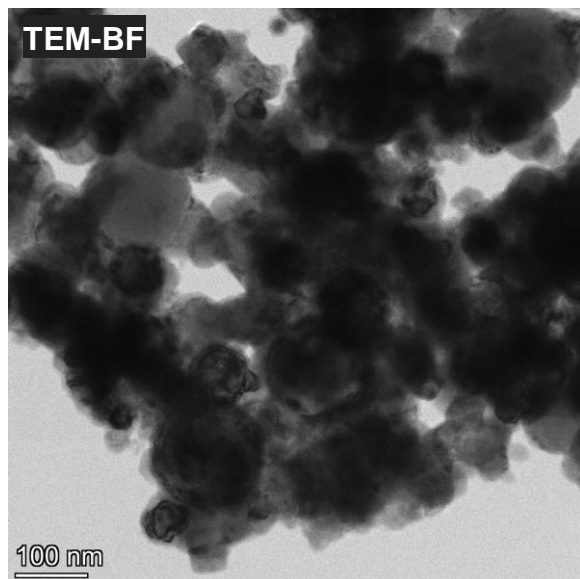
Bright field image



Dark field image

Conventional TEM Imaging

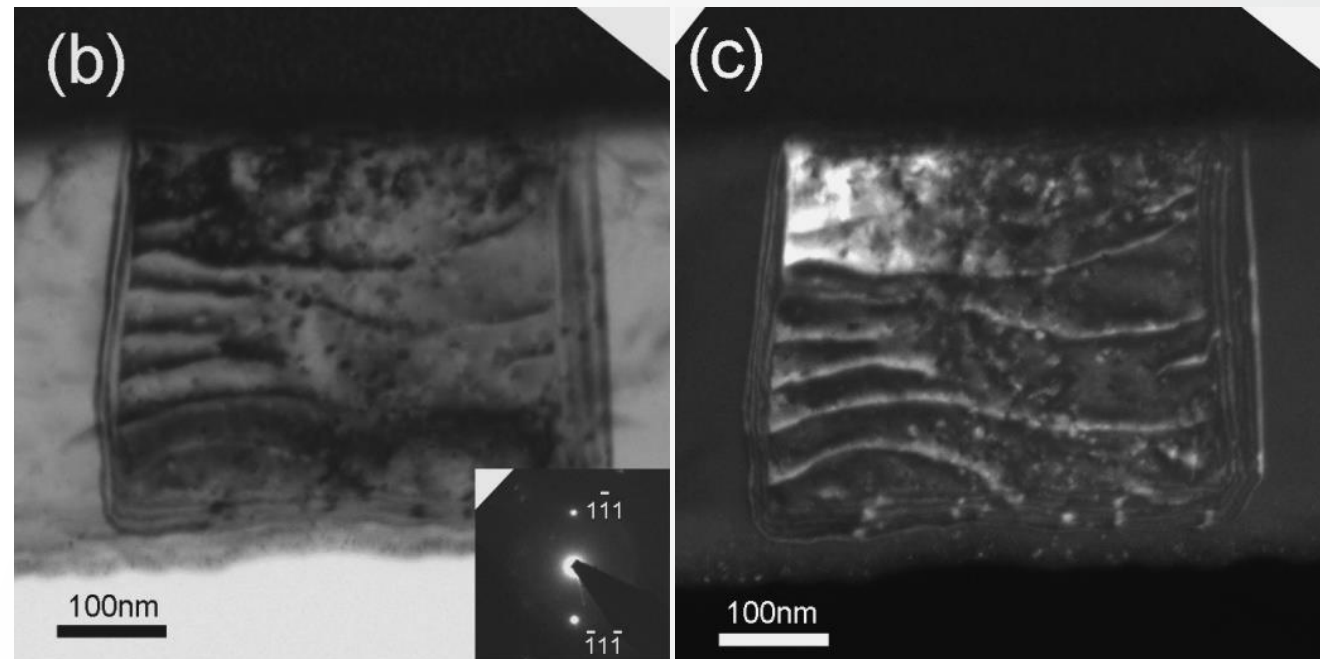
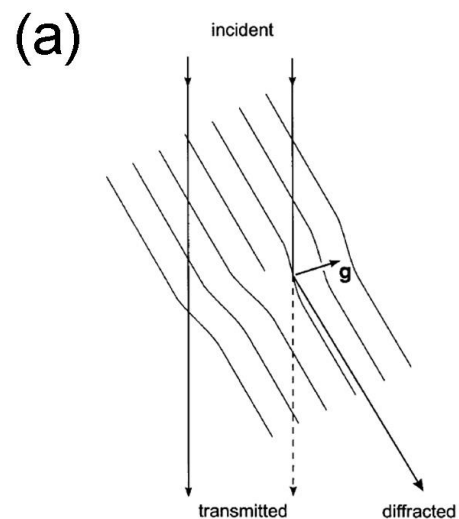
Bright and Dark Field Imaging



Conventional TEM Imaging

Benefit of Dark Field Image

- Grain Orientation
- Defect Analysis
- Phase formation

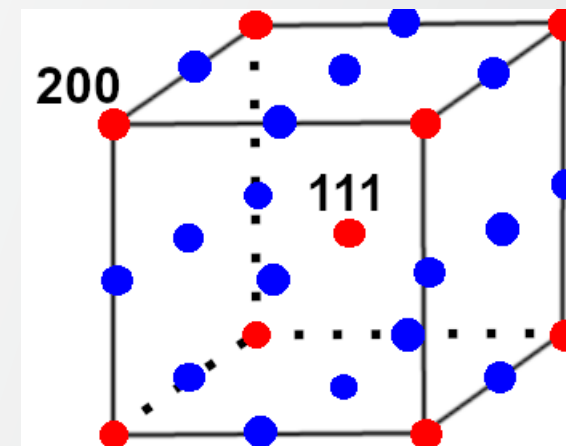
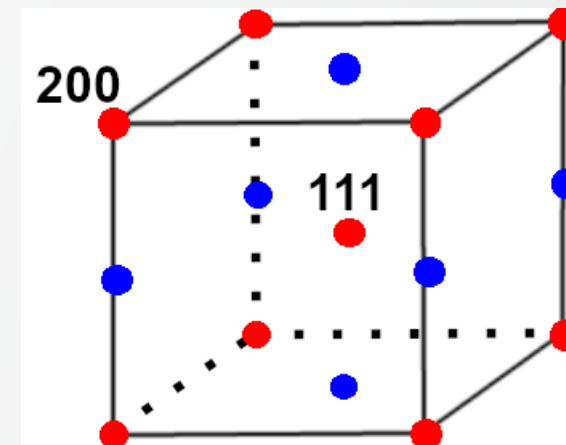
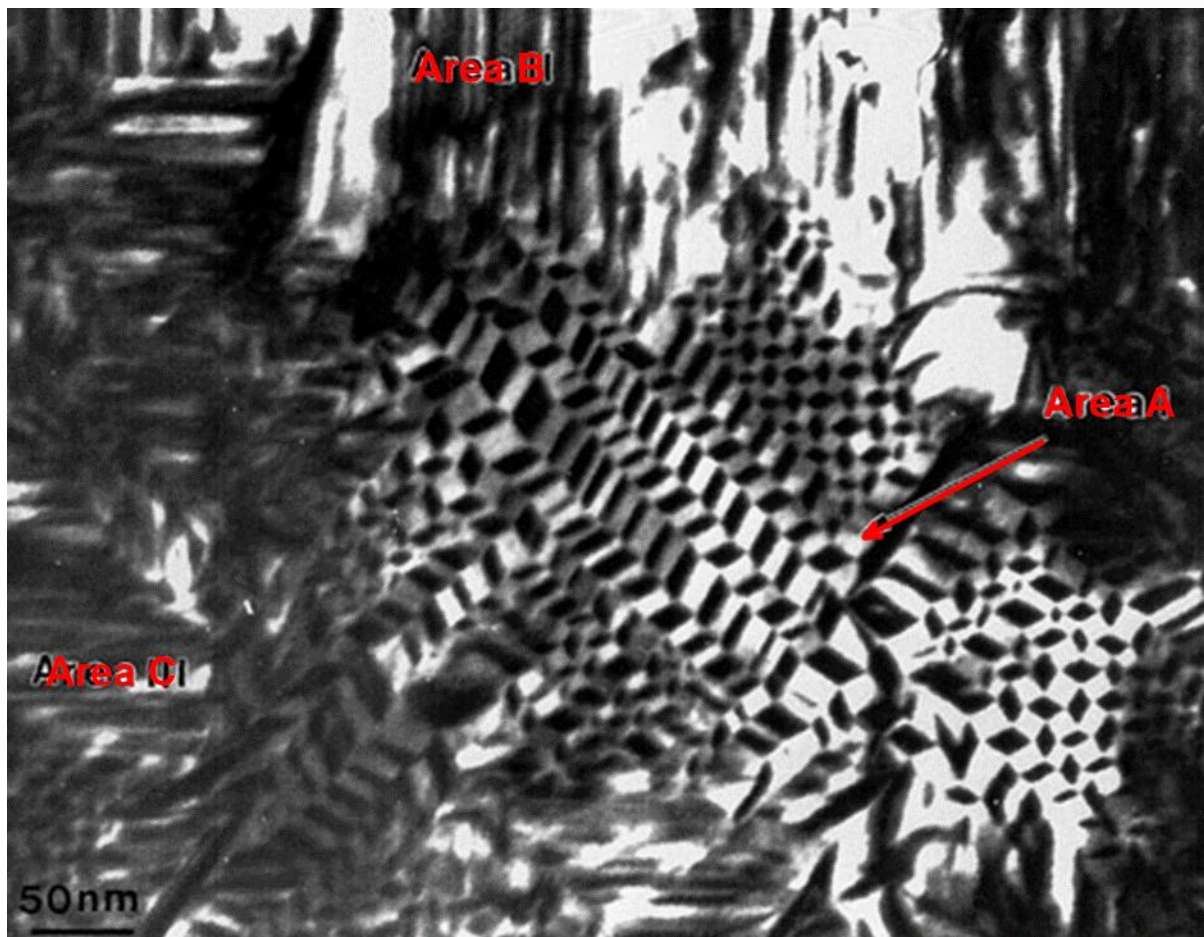


(a) Planes near an edge dislocation bend into the orientation for diffraction (b) BF image and (c) DF image of dislocations under a two-beam condition in an Al thin film. The inset in (b) shows the SAED pattern indicating the orientation condition for BF imaging.

Conventional TEM Imaging

Benefit of Dark Field Image

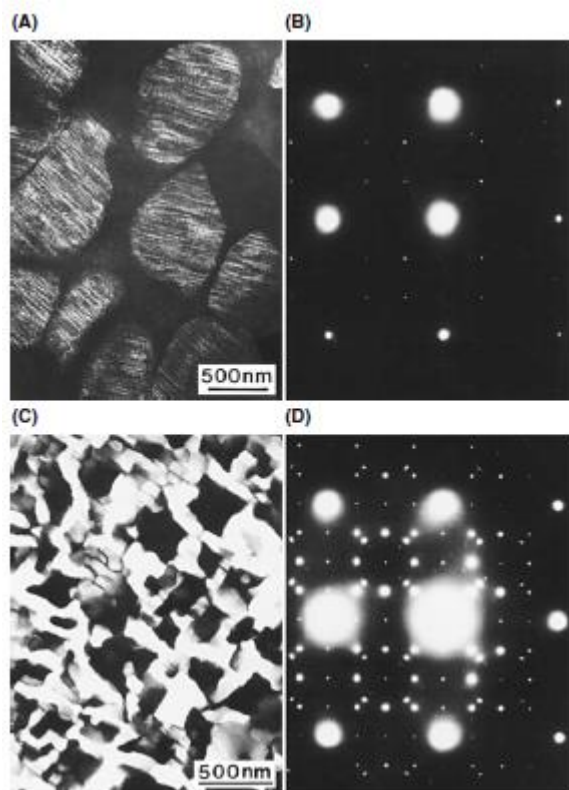
Regions of one variant or one phase are made visible by selecting a single Bragg reflection for imaging



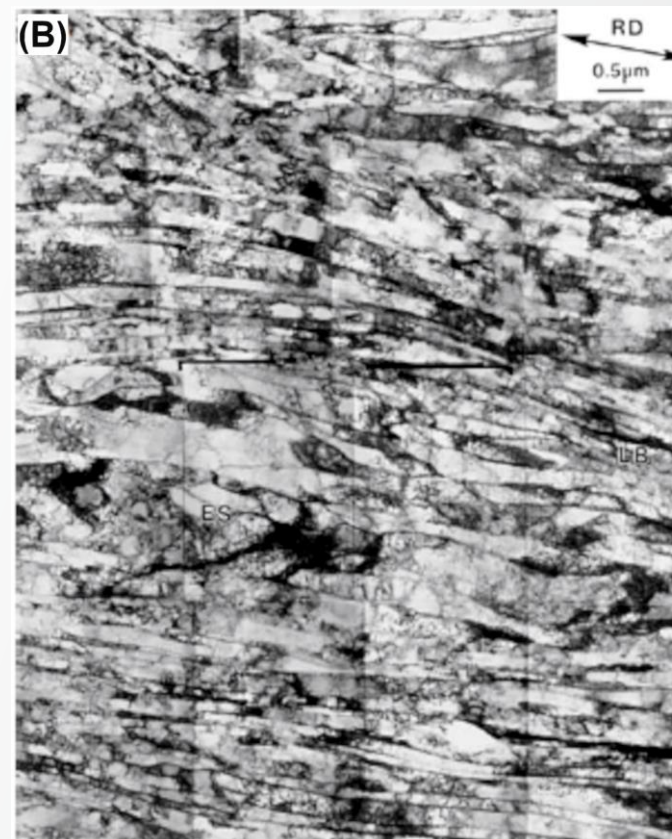
Conventional TEM Imaging

Benefit of Dark Field Image

(A) DF image of ordered V₆C₅ and (B) accompanying DP. (C) DF image of V₈C₇ and (D) DP. In both carbides, the ordering is due to vacancies on the C sublattice



Dislocation walls in Al which have been heavily deformed by directional rolling. (200-keV electrons but super specimen.)



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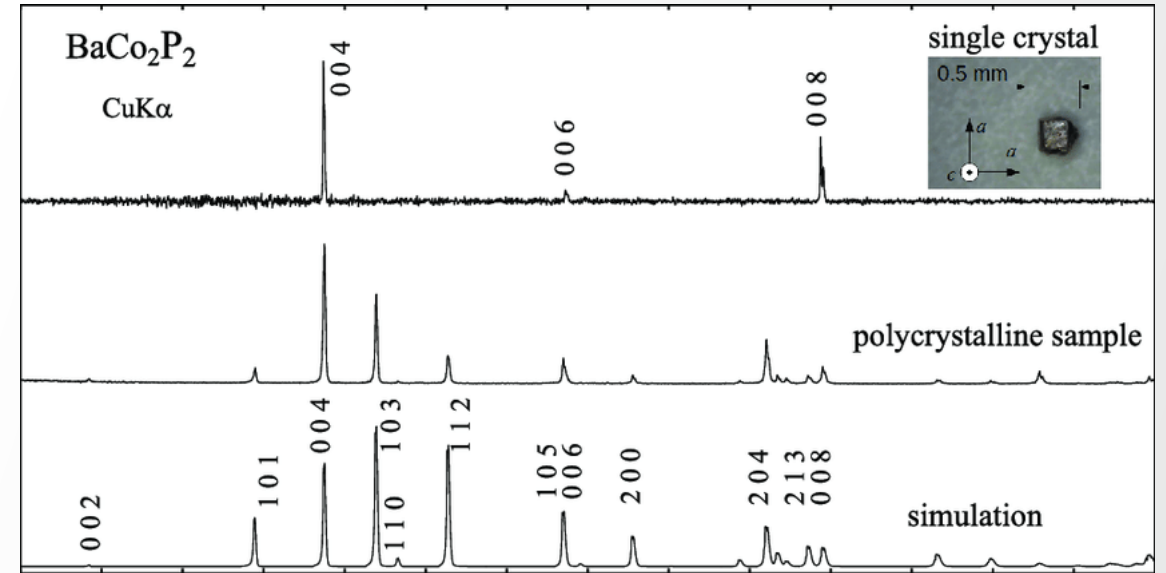
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Electron Diffraction

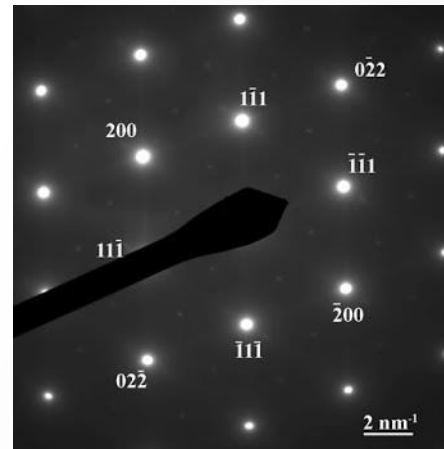
X-rays vs Electron Diffraction

X-rays vs Electron Diffraction		
Parameter	X-rays	Electron
Analysis	Intensity and position	Position
Type of wavelength for single crystal	Multi-wavelength	Single-wavelength
Acquisition time	Minutes to hours	Less than second

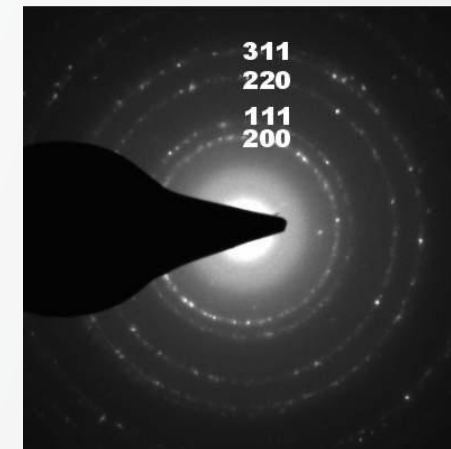


Important facts about electron for diffraction:

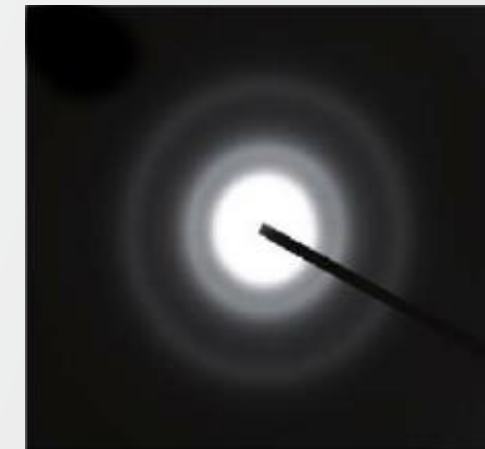
- Electrons have shorter λ than X-rays
- Electron scattered more strongly
- Electron beams are easily directed



Single crystalline SAED pattern



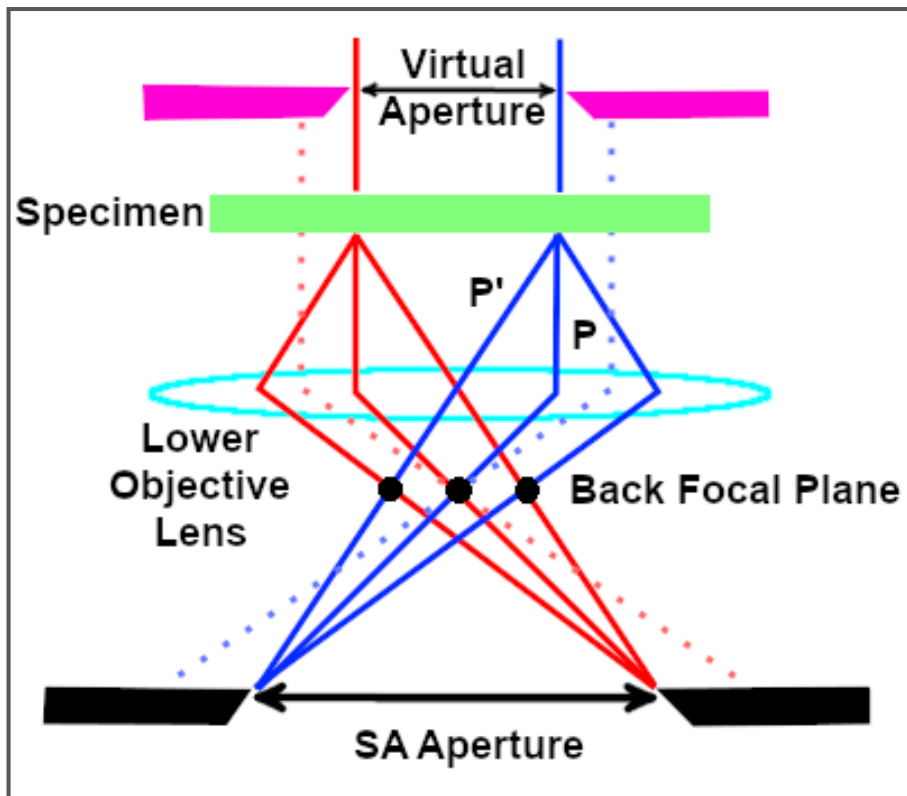
Poly-crystalline SAED pattern



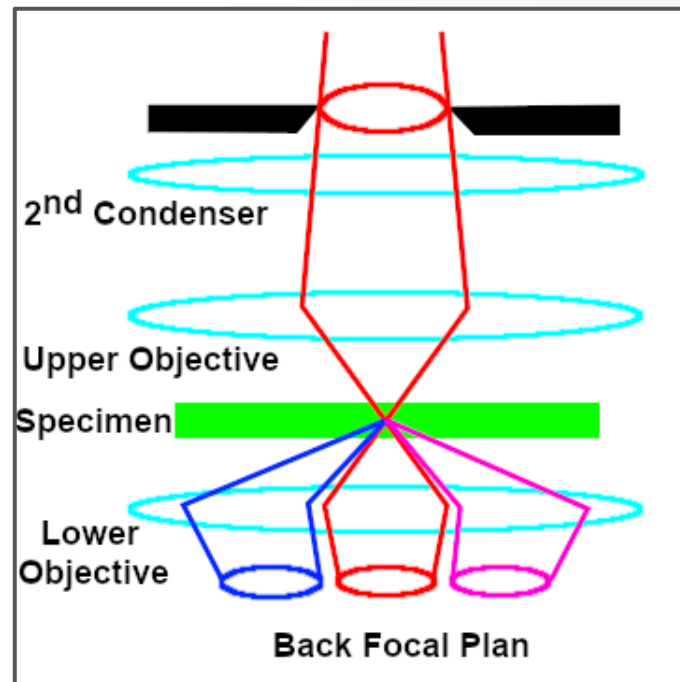
Amorphous SAED pattern

Electron Diffraction

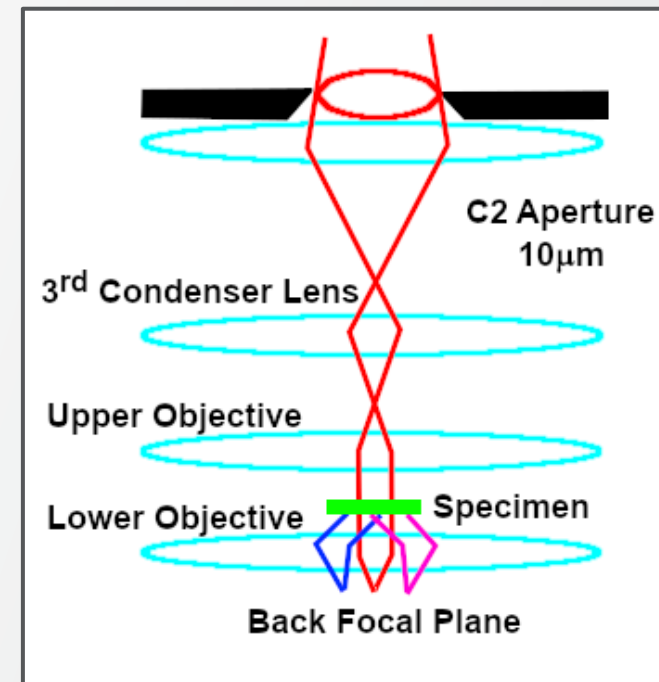
Type of Electron Diffraction in TEM



Selected Area Electron Diffraction (SAED)



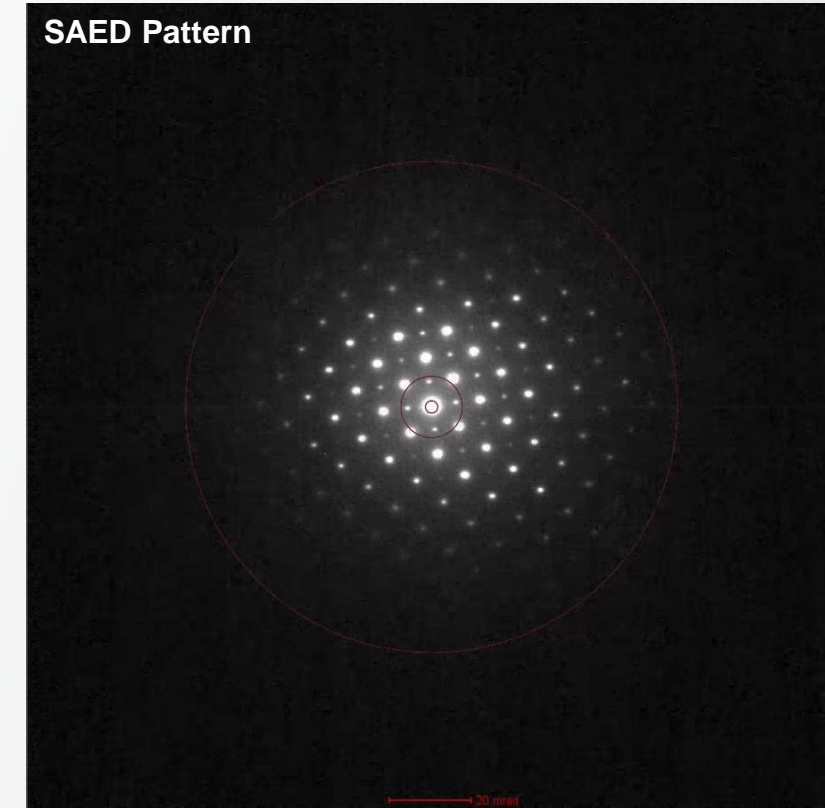
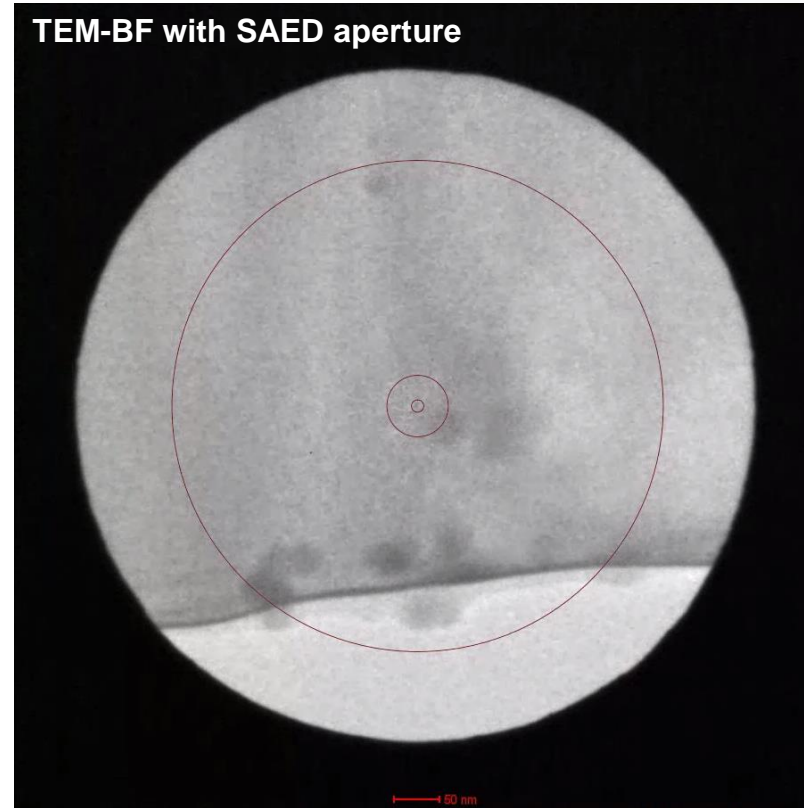
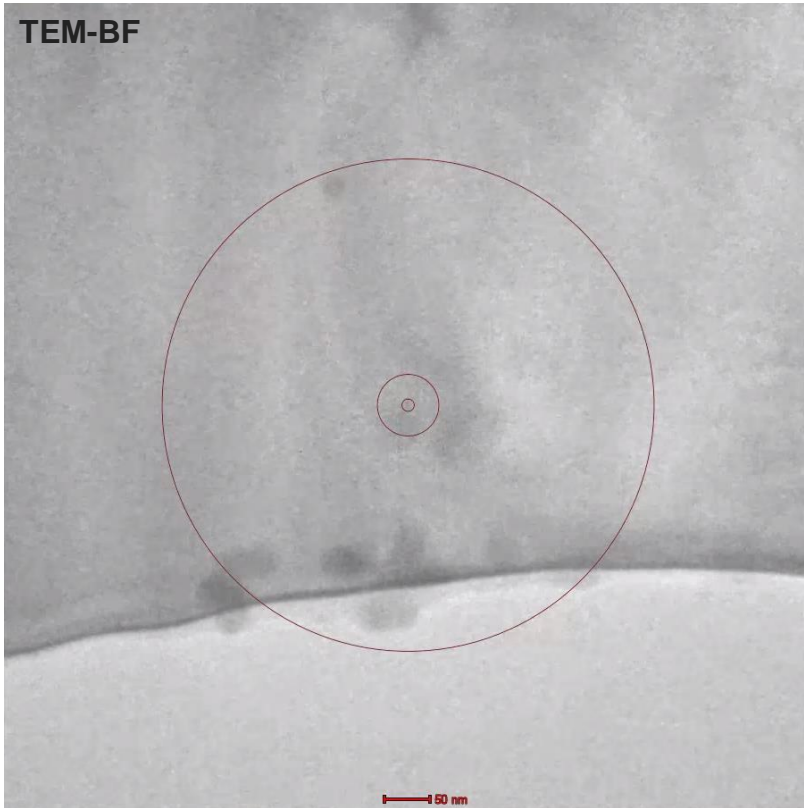
Convergence Beam
Electron Diffraction (CBED)



Nano Beam
Electron Diffraction (NBED)

Electron Diffraction

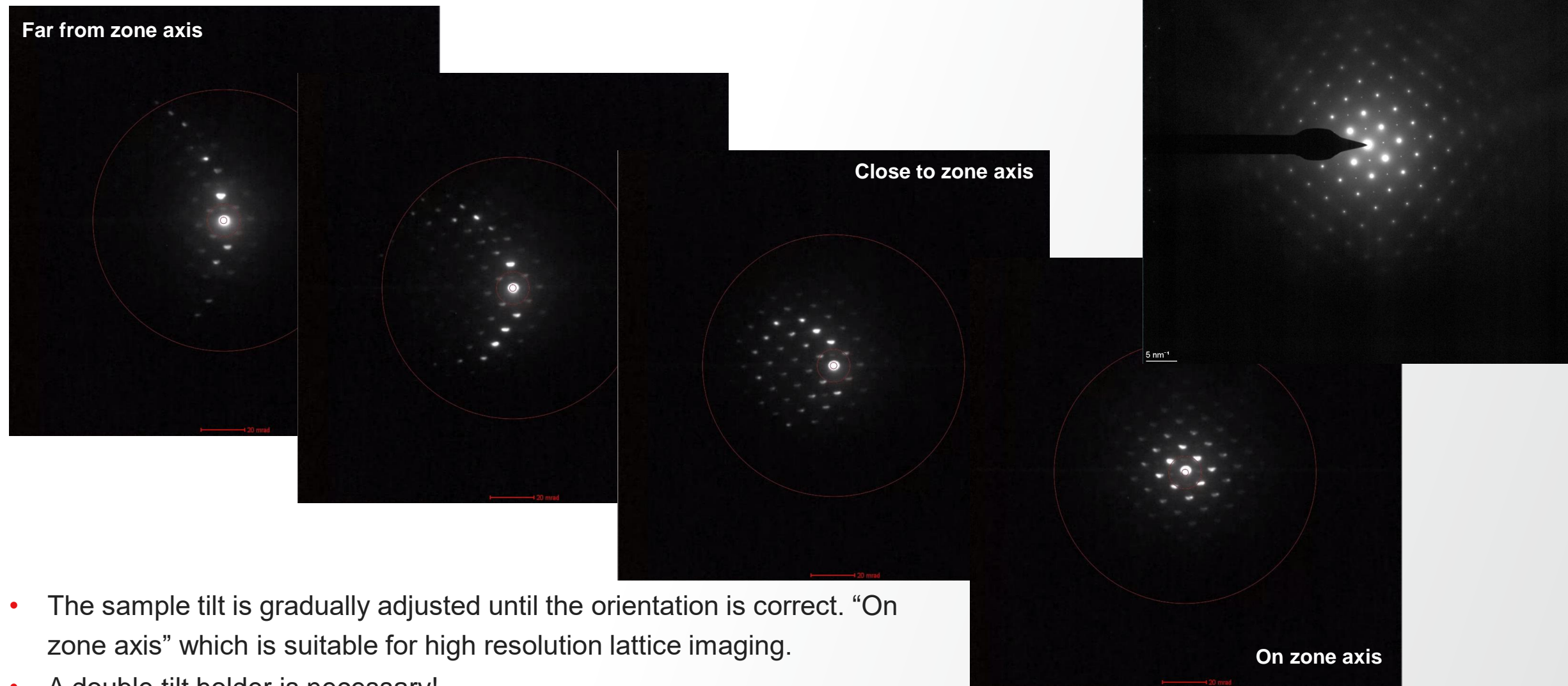
Selected Area Electron Diffraction (SAED)



As the name, the aperture is always needed to select an area and produce the Electron Diffraction Pattern

Electron Diffraction

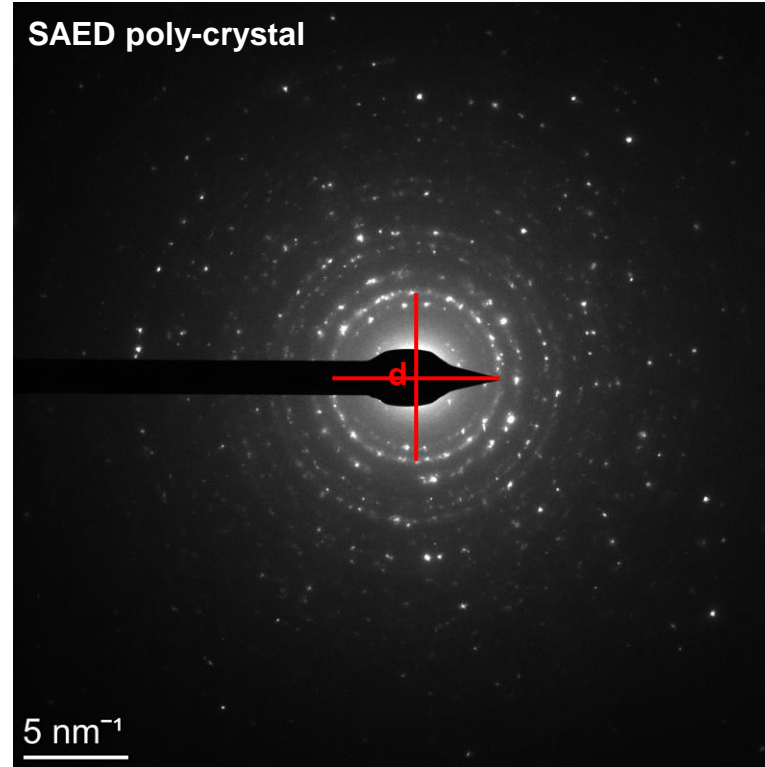
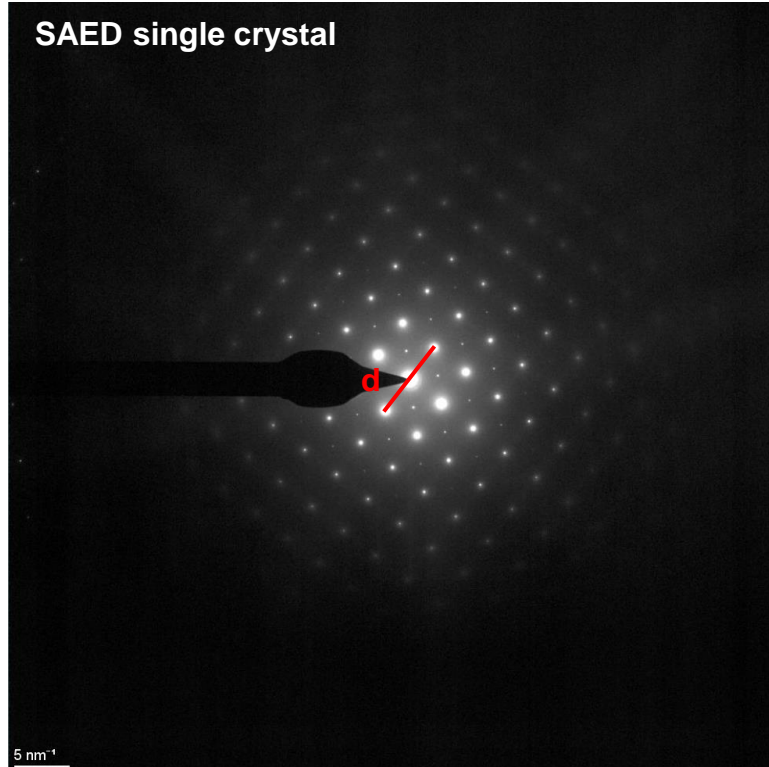
Orienting a single crystal using the diffraction pattern



- The sample tilt is gradually adjusted until the orientation is correct. “On zone axis” which is suitable for high resolution lattice imaging.
- A double tilt holder is necessary!

Electron Diffraction

(An Overview) SAED Pattern Analysis

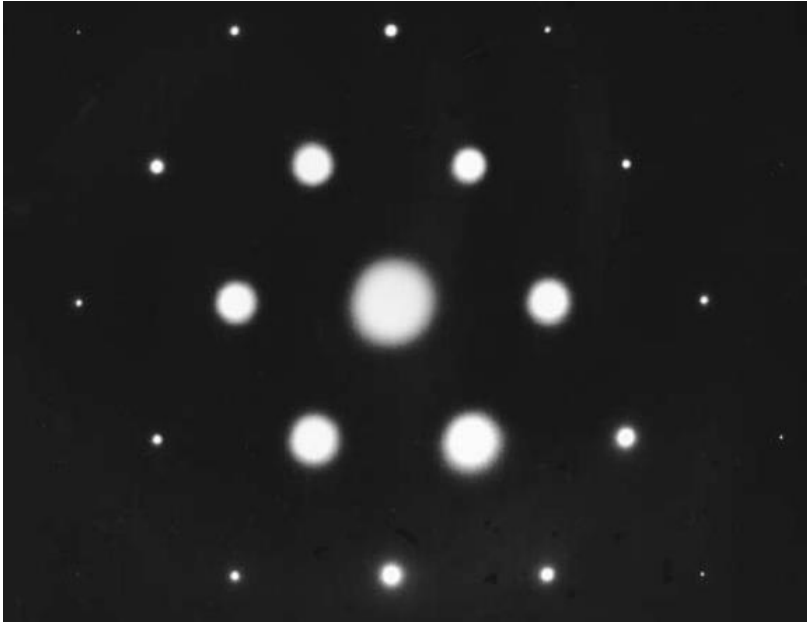


- Make sure that the microscope is calibrated
- Measure the distance from reflections or rings to the main spot ($d/2$)
- Inversed the measured value
- Compare the data (d-spacing) with database to find the phase presence

Electron Diffraction

Convergence beam electron diffraction (CBED)

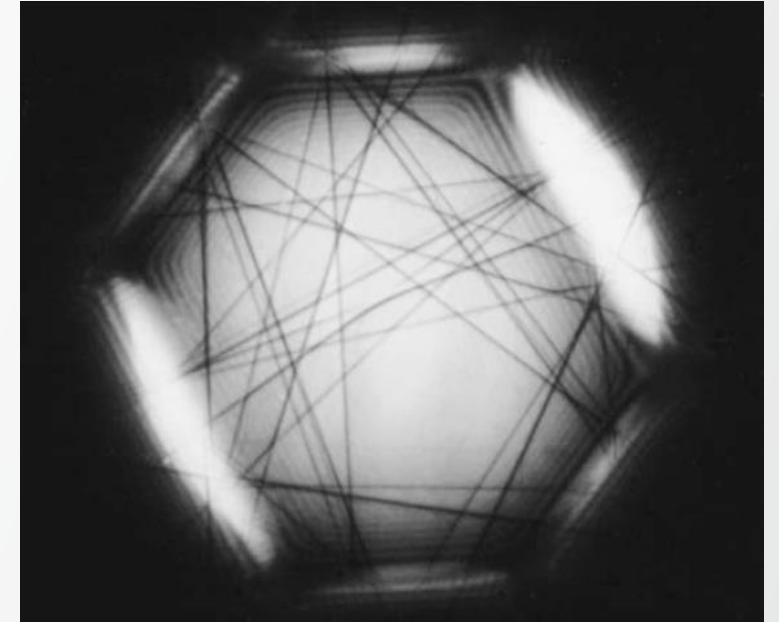
SAED pattern of Si <111>



CBED pattern of Si <111>



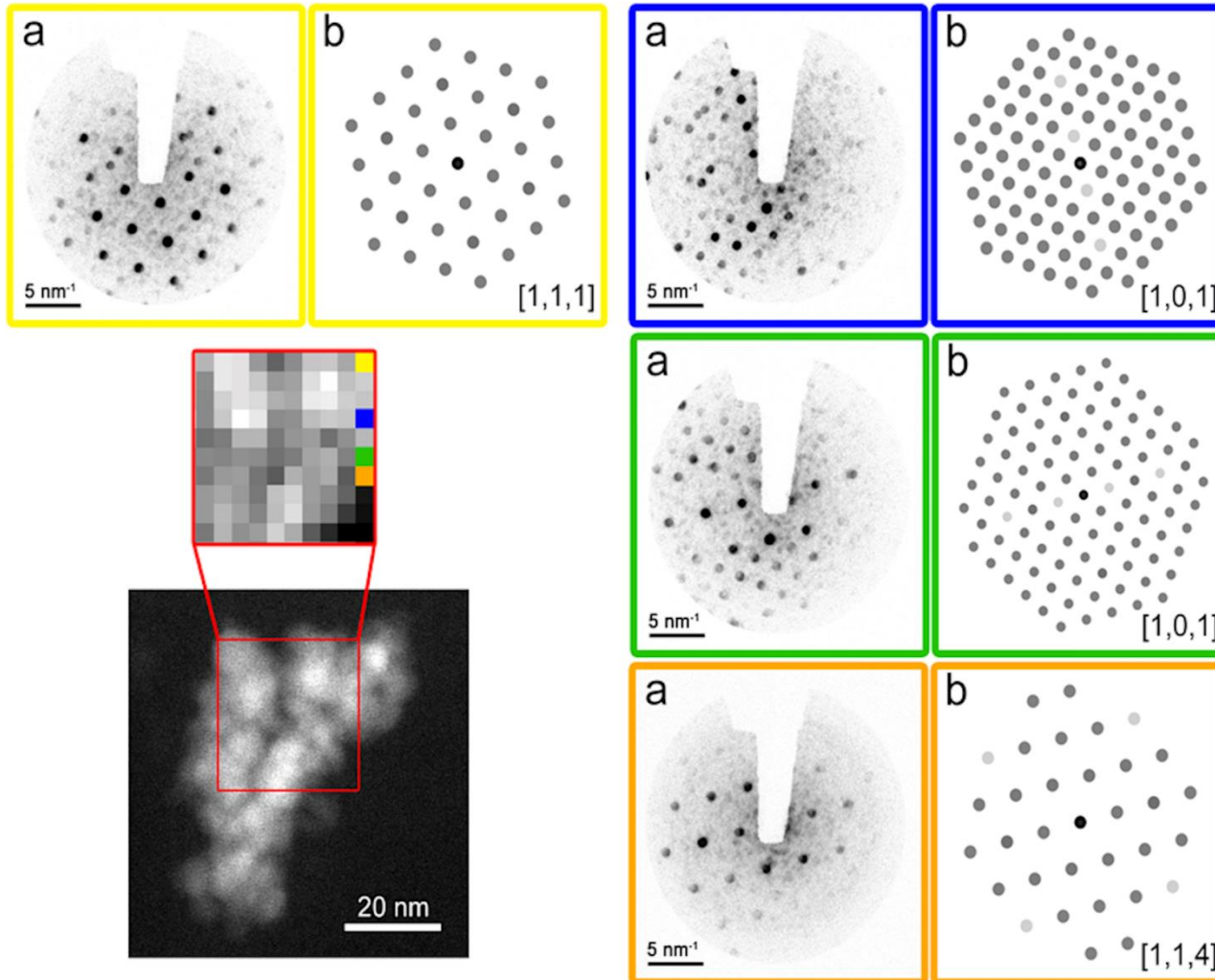
AI HOLZ line pattern



- Small area ≤ 100 nm
- CBED gives quantitative data on
 - Specimen thickness
 - Crystallographic data such as unit cells, Bravais lattice, crystal system and 3D full symmetry
 - Precise lattice-strain measurements
 - Valence-electron distribution, structure factor, and chemical bonding
 - Characterization online and planar defects

Electron Diffraction

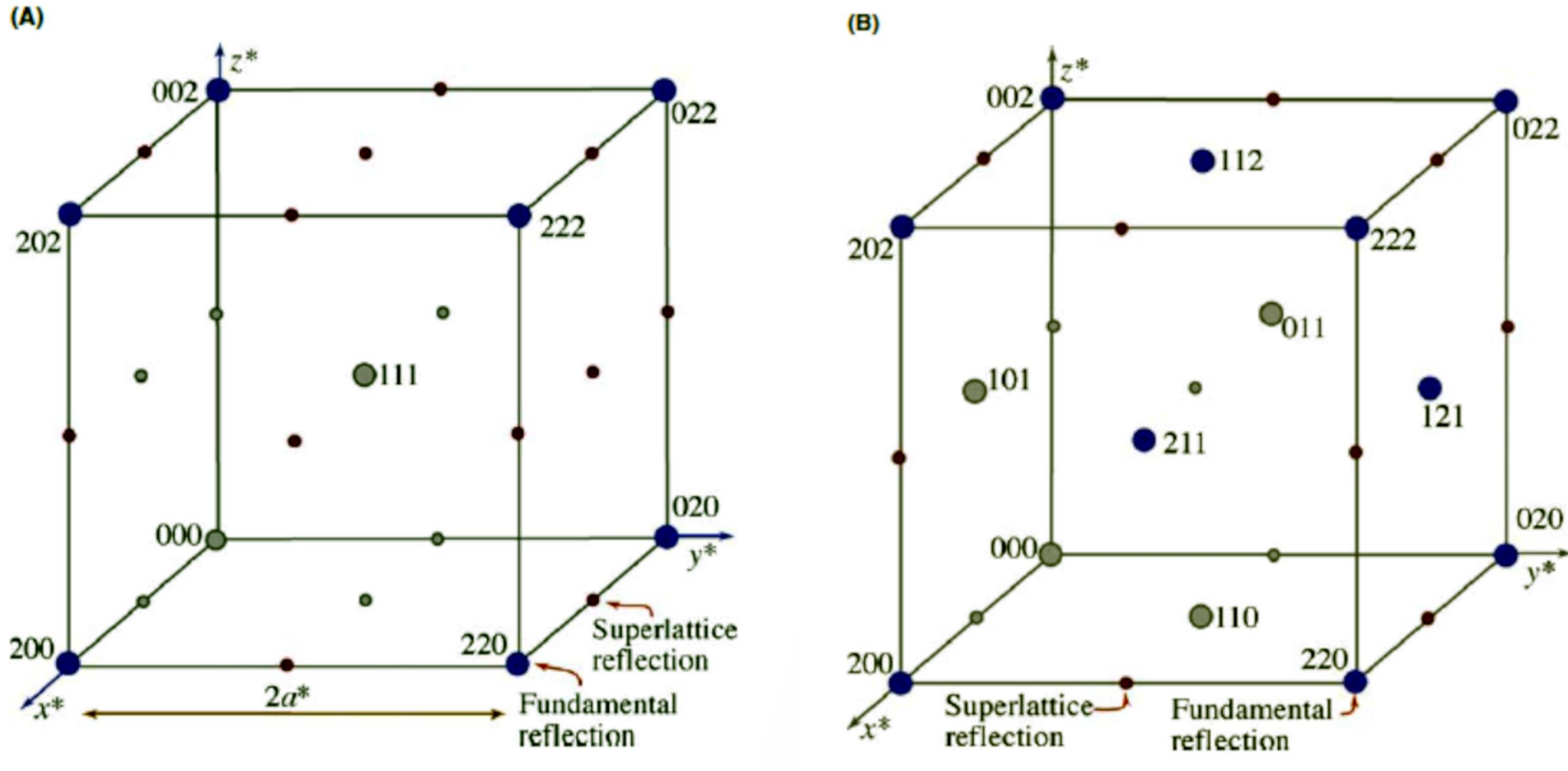
Nano Beam Electron Diffraction



- Nanocrystals of Fe_3O_4 (magnetite), which have been incorporated in melt spinning polyvinylidene fluoride (PVDF) fibers.
- Experimental NBED in STEM mode (a) with corresponding simulated pattern (b).
- The frame colors refer to the position of electron beam during acquisition of the diffraction patterns.
- Domains or particles can be analyzed at nm-range by collection electron diffraction pattern.

Electron Diffraction

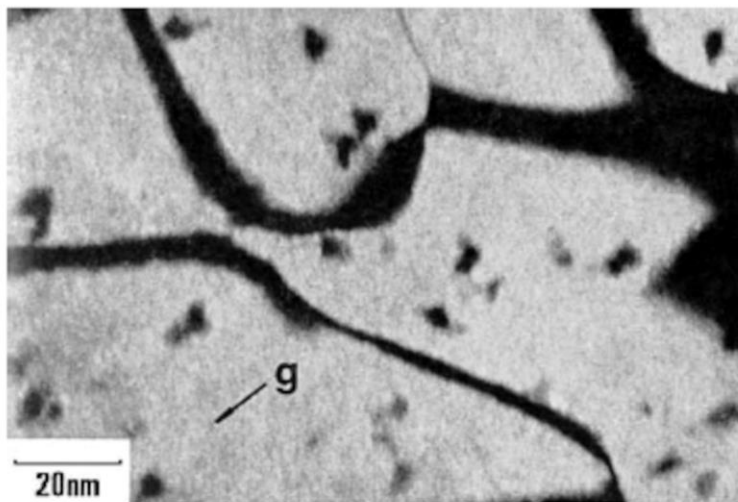
Information from Electron Diffraction (SAED) – Superlattice Reflections



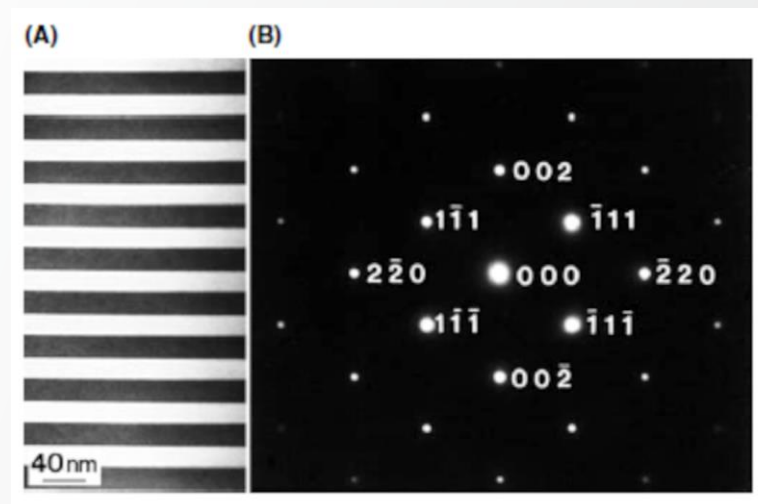
The reciprocal lattice for (A) the Ni₃Al and (B) the NiAl structures. In (A), Ni₃Al is fcc, so the fcc-forbidden reflections (h, k, l mixed even and odd) are allowed and become chemically sensitive (superlattice) reflections. In (B), NiAl is bcc, so the bcc-forbidden reflections (if h + k + l odd) are now allowed superlattice reflections.

Electron Diffraction

Information from Electron Diffraction (SAED) – Superlattice Reflections



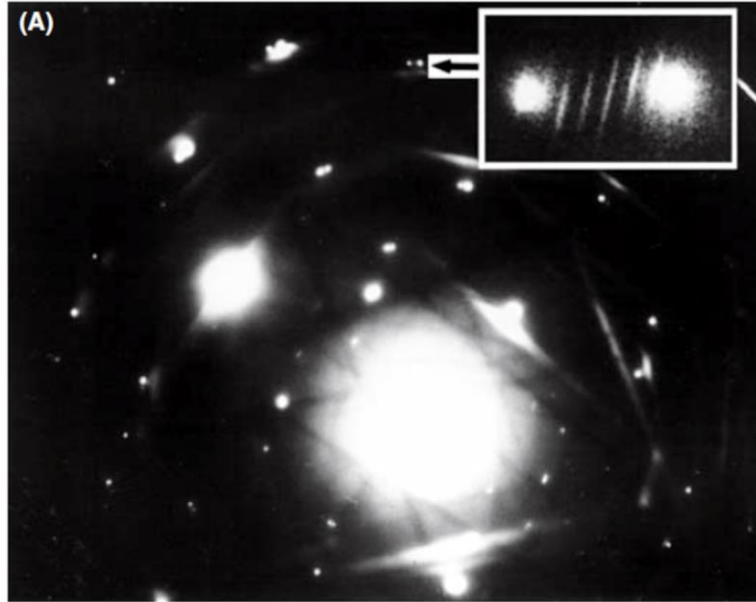
DF image from a chemically sensitive 110 reflection showing bright ordered domains in Cu_3Au . The dark areas in the bright domains are regions of local disorder induced by ion beam damage



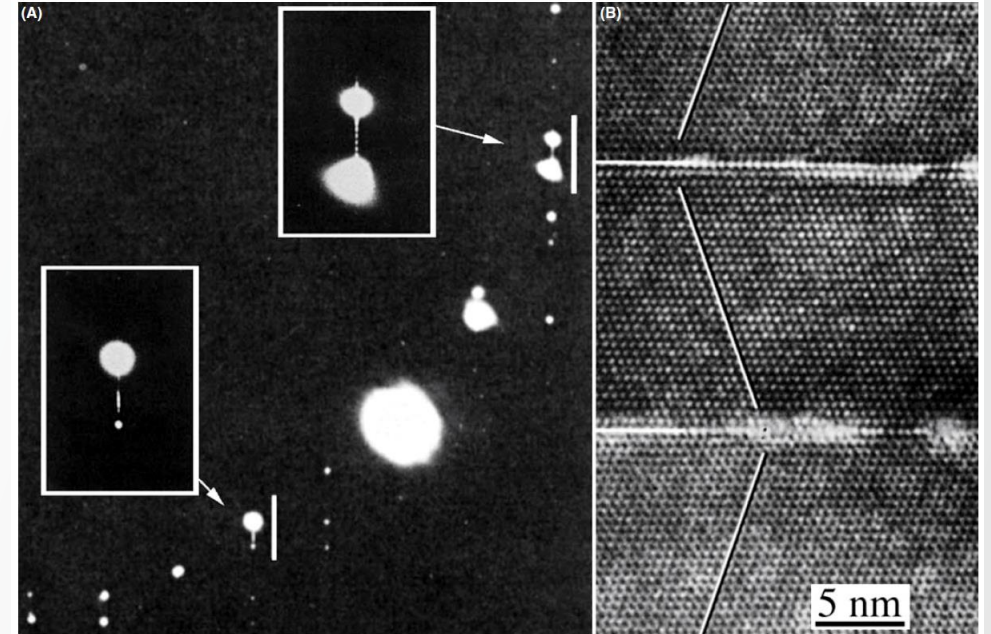
(A) DF image from 002 chemically sensitive reflection in $\text{GaAs}/\text{Al}_x\text{Ga}_{1-x}\text{As}$. The $\text{Al}_x\text{Ga}_{1-x}\text{As}$ is the lighter region because Al has replaced Ga in the GaAs (darker region). (B) DP showing the less intense 002 and other superlattice reflections.

Electron Diffraction

Information from Electron Diffraction (SAED) – Extra Spots



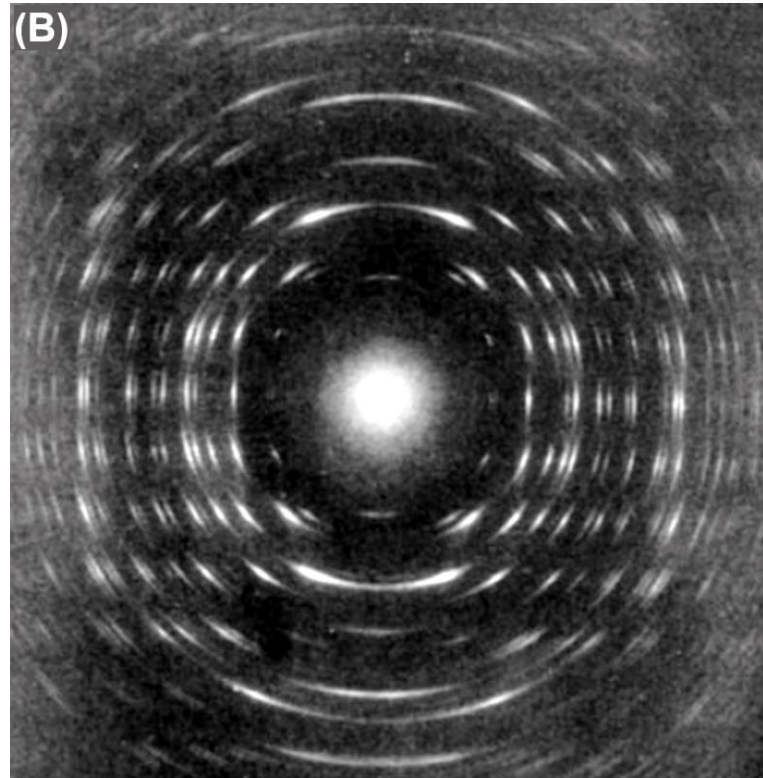
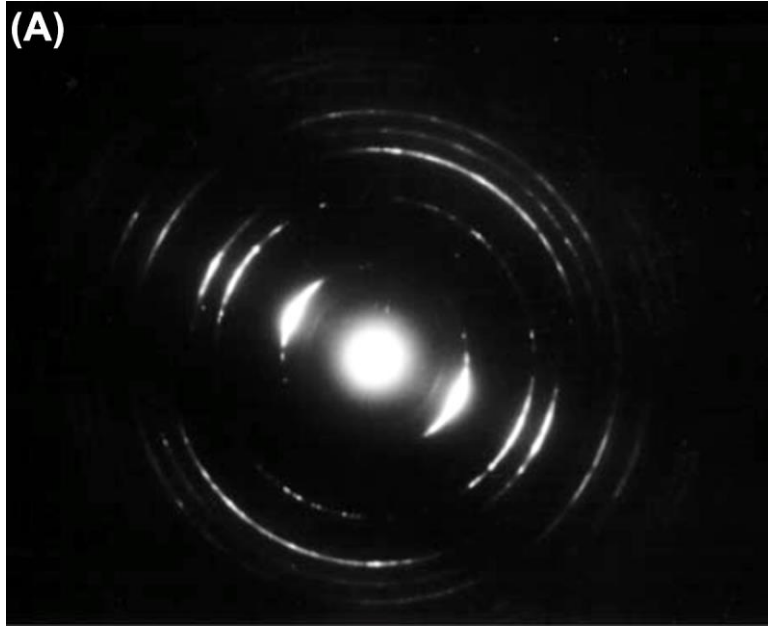
(A) The set of streaks from an array of dislocations in Al_2O_3 lying parallel to the electron beam. The distance between the streaks is inversely related to the spacing of the dislocations shown in image (B)



Extra spots can be formed in the DP (A) when only two defects are scattering in phase. The separation of the extra spots is related to the inverse separation of the two twin boundaries seen in image (B).

Electron Diffraction

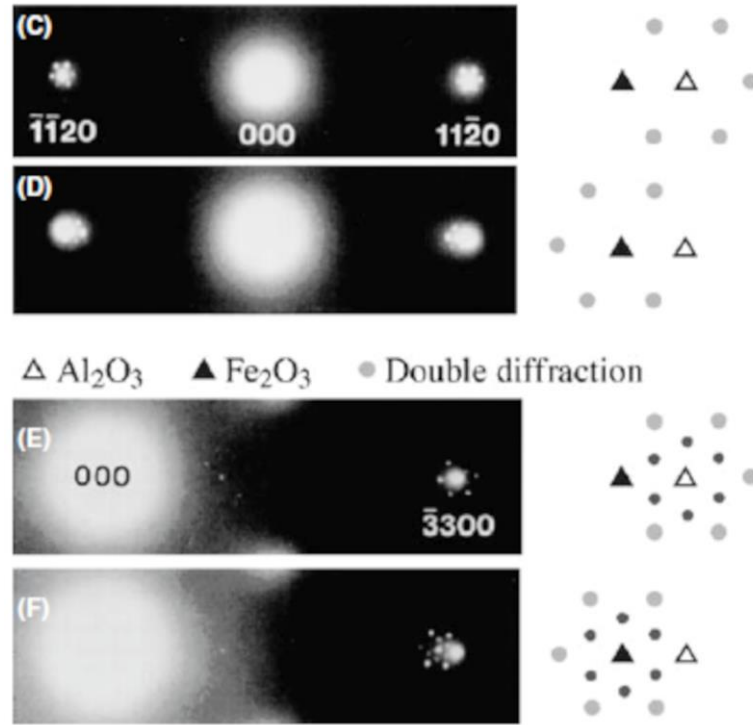
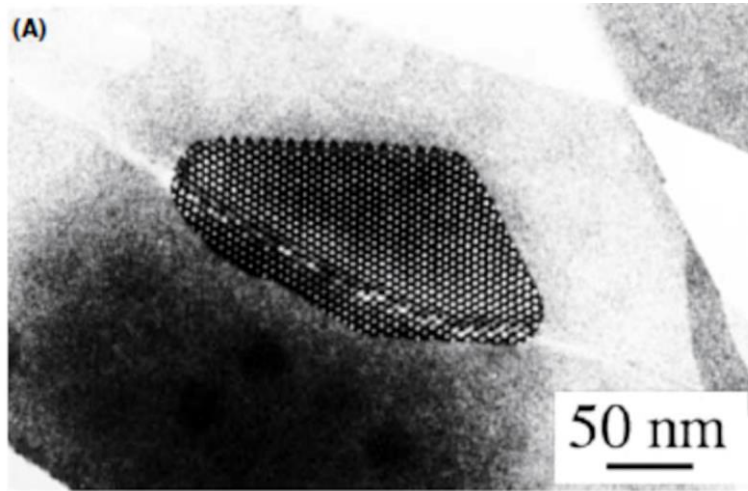
Information from Electron Diffraction (SAED) – Texture ED Patterns



(A) A texture ring pattern where the rings are more intense over a certain angular range. (B) The corresponding interception of the Edwald sphere (plane) with the reciprocal lattice. (C) A DF image of the texture grains, taken from a brighter position of one of the hkl rings, shows an equiaxed structure. In (D), the specimen is textured about a direction at an angle to the beam, so the Edwald sphere creates elongated spots or arcs in the DP.

Electron Diffraction

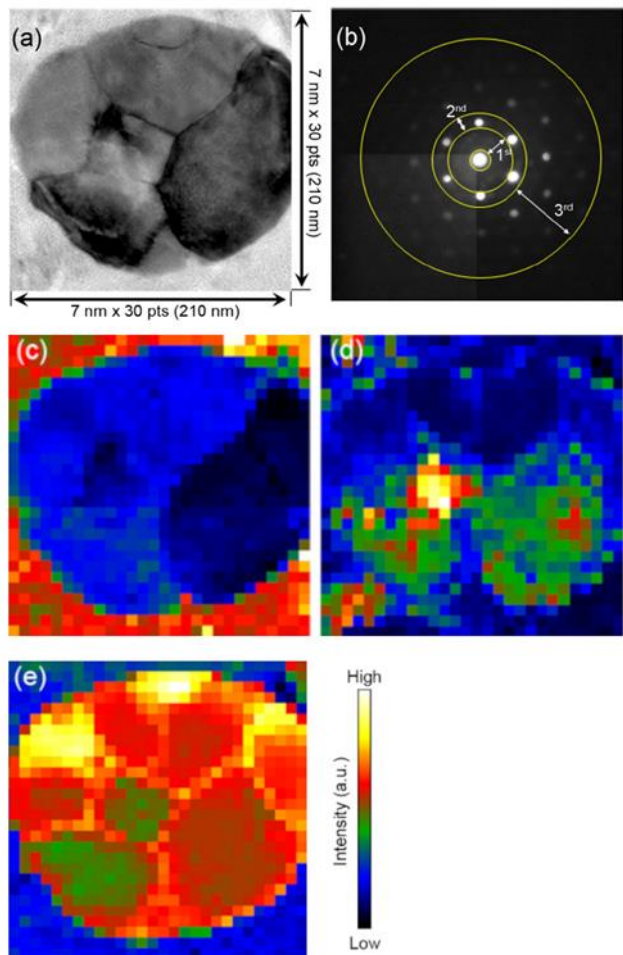
Information from Electron Diffraction (SAED) – Double-Diffraction



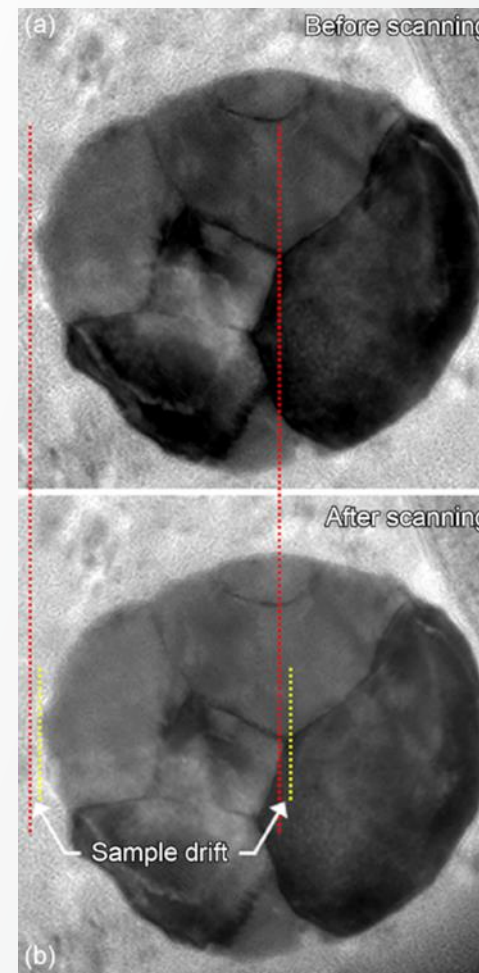
- (A) BF on-axis image of a particle of $\alpha\text{-Fe}_2\text{O}_3$ on $\alpha\text{-Al}_2\text{O}_3$.
- (B) [0001] SADP from $\alpha\text{-Fe}_2\text{O}_3$ showing double-diffraction spots around the [11-20] and [3-300] reflections.
- (C) Enlargements of regions near the [11-20] reflections when hematite island is on the top surface.
- (D) Enlargements of the region near the [11-20] reflections when the hematite island is on the bottom.
- (E) Enlargements of regions near the [3-300] reflections when the hematite island is on the top surface.
- (F) Enlargements of regions near the [3-300] reflections when the hematite island is on the bottom.

Electron Diffraction

Scanning Nano Electron Diffraction (SNED) of Nanostructured Au Disk



(a) A BF image of nanostructured Au disk and (b) selected diffraction pattern acquired from SEND. The diffraction intensity is integrated for the areas of 1, 2, and 3 represented in (b). The corresponding maps are shown in (c), (d) and (e), respectively.



Sample drift during SEND. (a) is the initial position, and (b) is the final position after SEND

Note: SNED requires the Scanning capability in TEM

Transmission Electron Microscopy Webinar Series

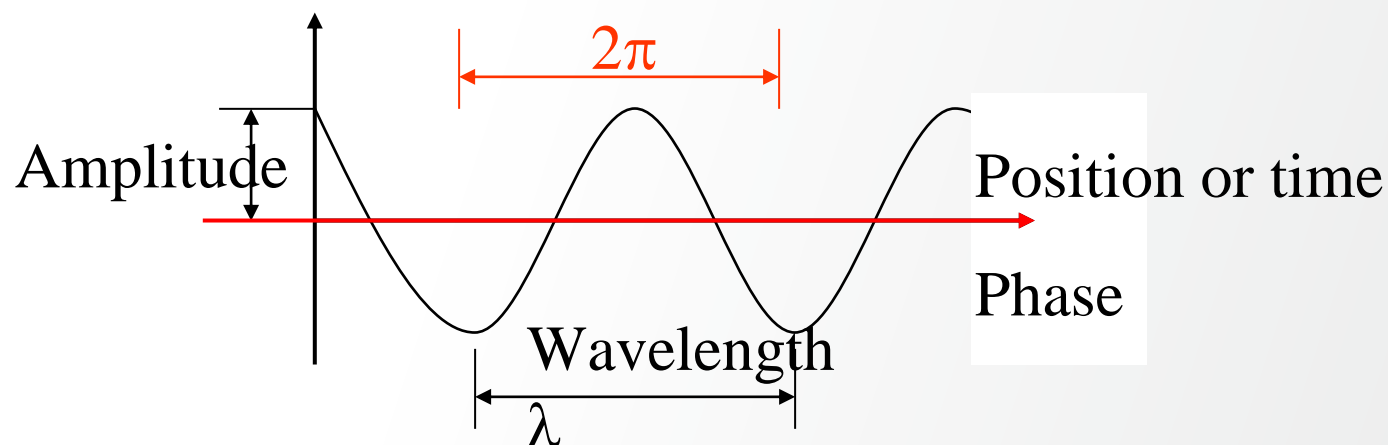
Outline: Part 01

- Basic Theory of TEM
- SEM vs. TEM: What are the differences
- Conventional TEM Imaging
 - Bright-Field Imaging
 - Dark-Field Imaging
- Electron Diffraction
 - Selective Area Electron Diffraction
 - Convergence Beam Electron Diffraction
 - Nano Beam Electron Diffraction
- Advanced TEM Imaging
 - High-resolution TEM
- Special Investigation Cases
 - Magnetic Samples
 - Soft Materials
 - In-situ Investigations
 - Life-Sciences

Advanced TEM Imaging: High-resolution TEM

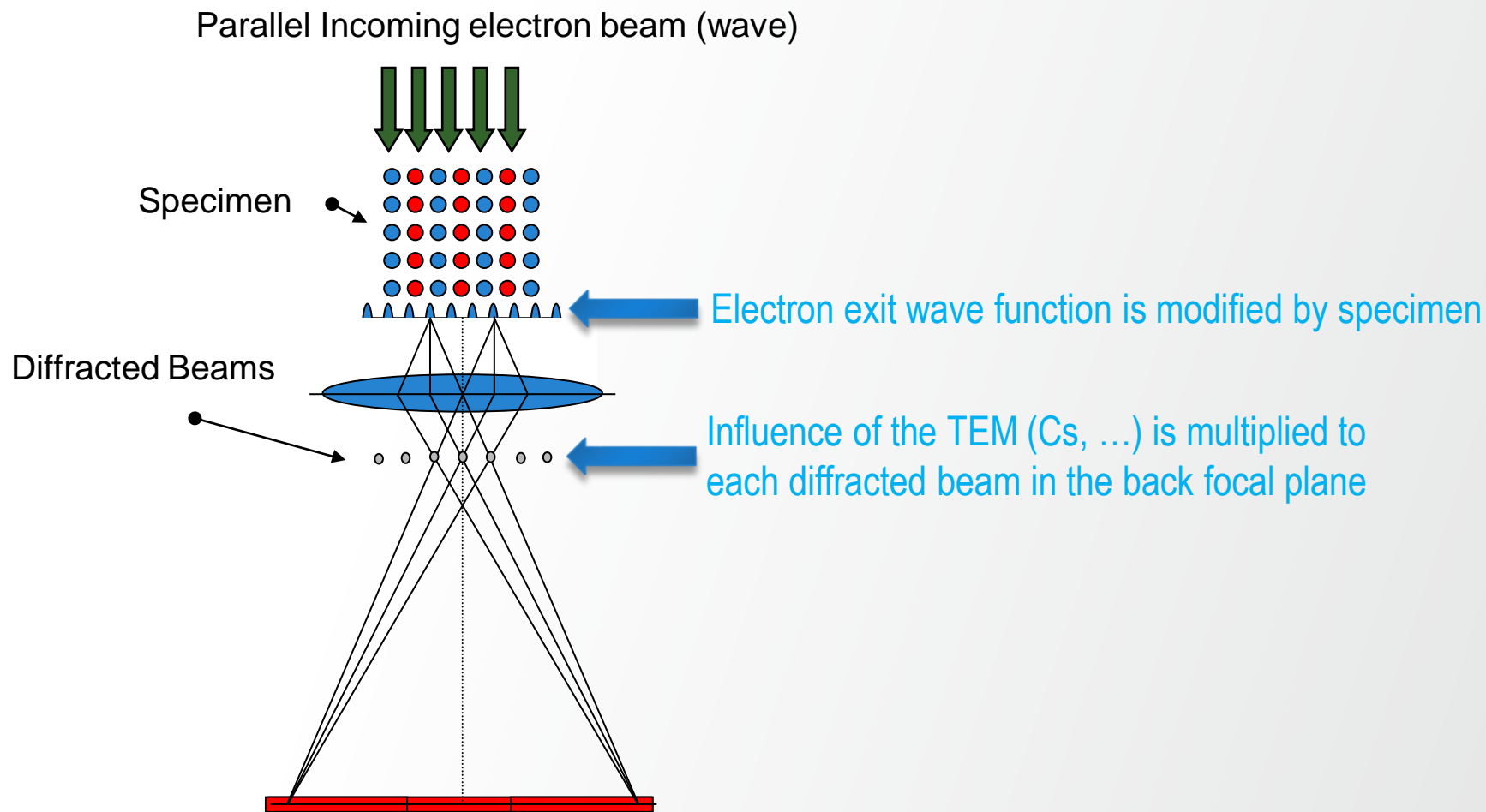
High-resolution TEM

- Electron beam is a wave with *amplitude (A) and phase (ϕ)*
- The periodicity is the wave-length (e.g. 0.0025nm at 200kV) or, in terms of phase, 2π



Advanced TEM Imaging: High-resolution TEM

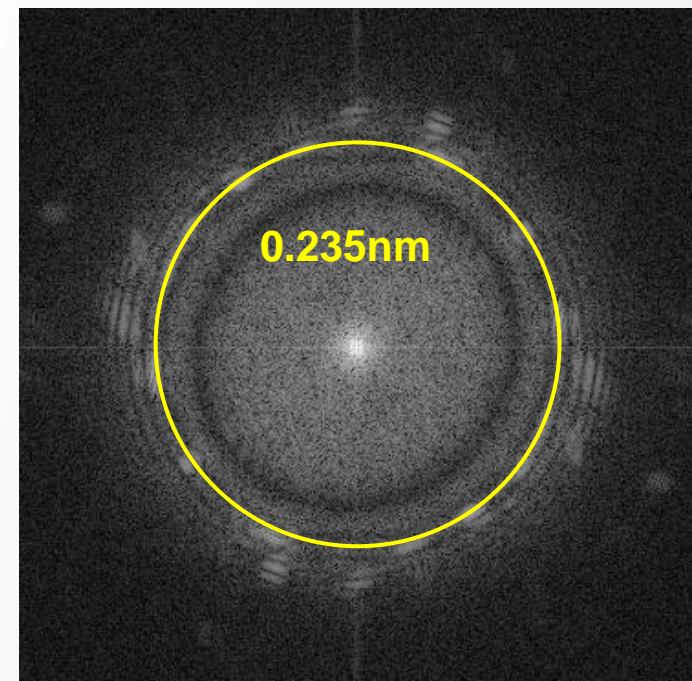
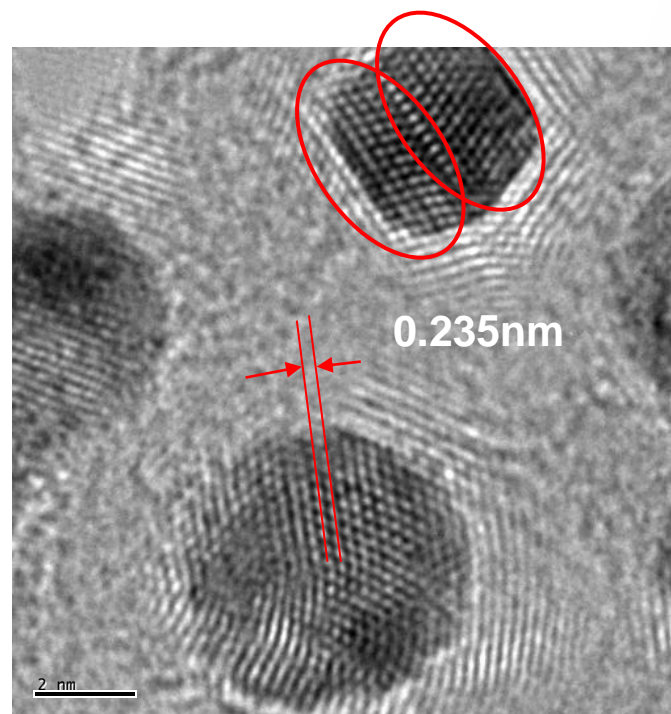
High-resolution TEM: Imaging Formation



Advanced TEM Imaging: High-resolution TEM

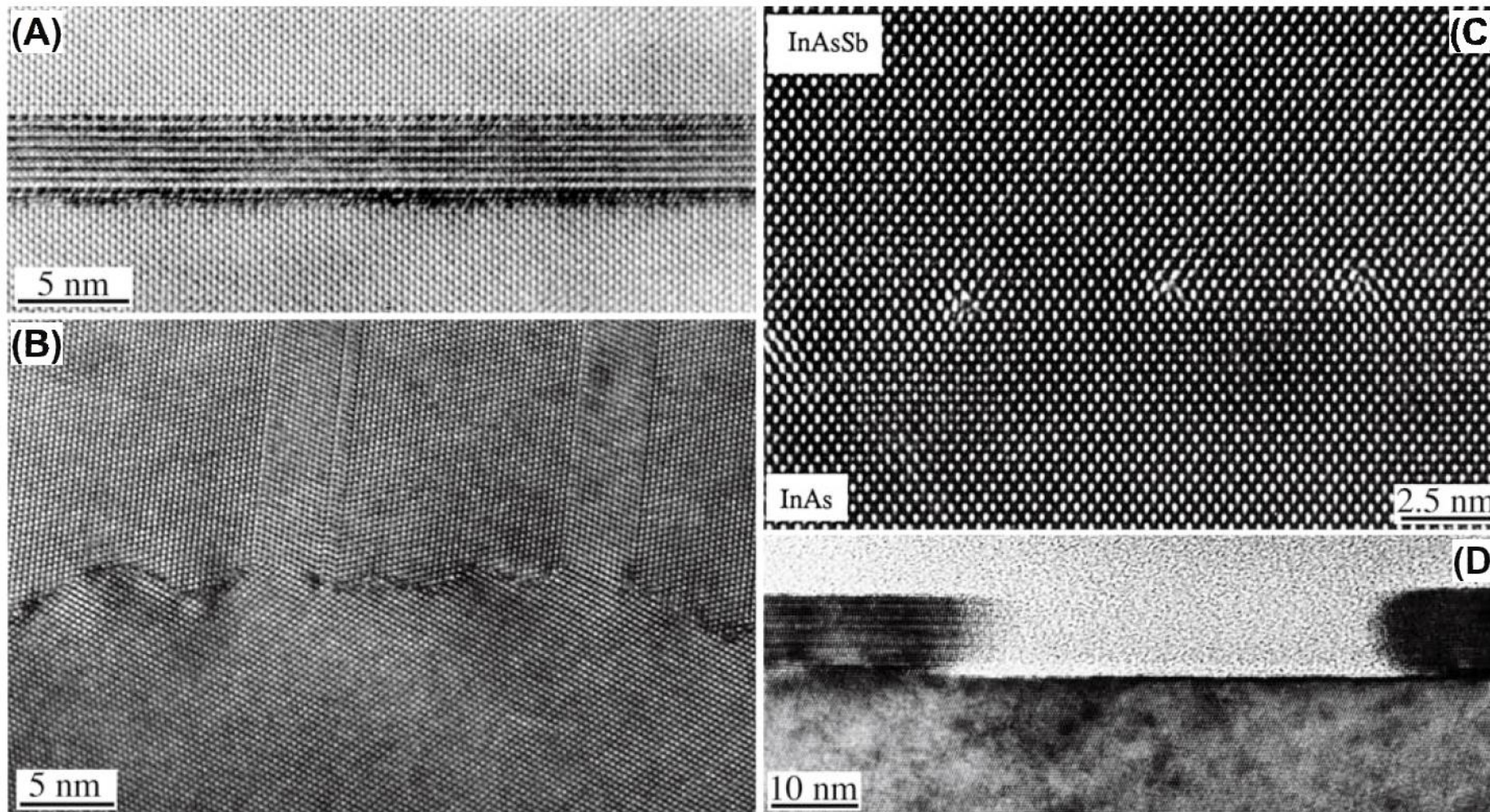
High-resolution TEM: What do we See on a HRTEM image?

Usually, you can not say where the atom is, but you can tell the distance on atomic scale and crystal defects



Advanced TEM Imaging: High-resolution TEM

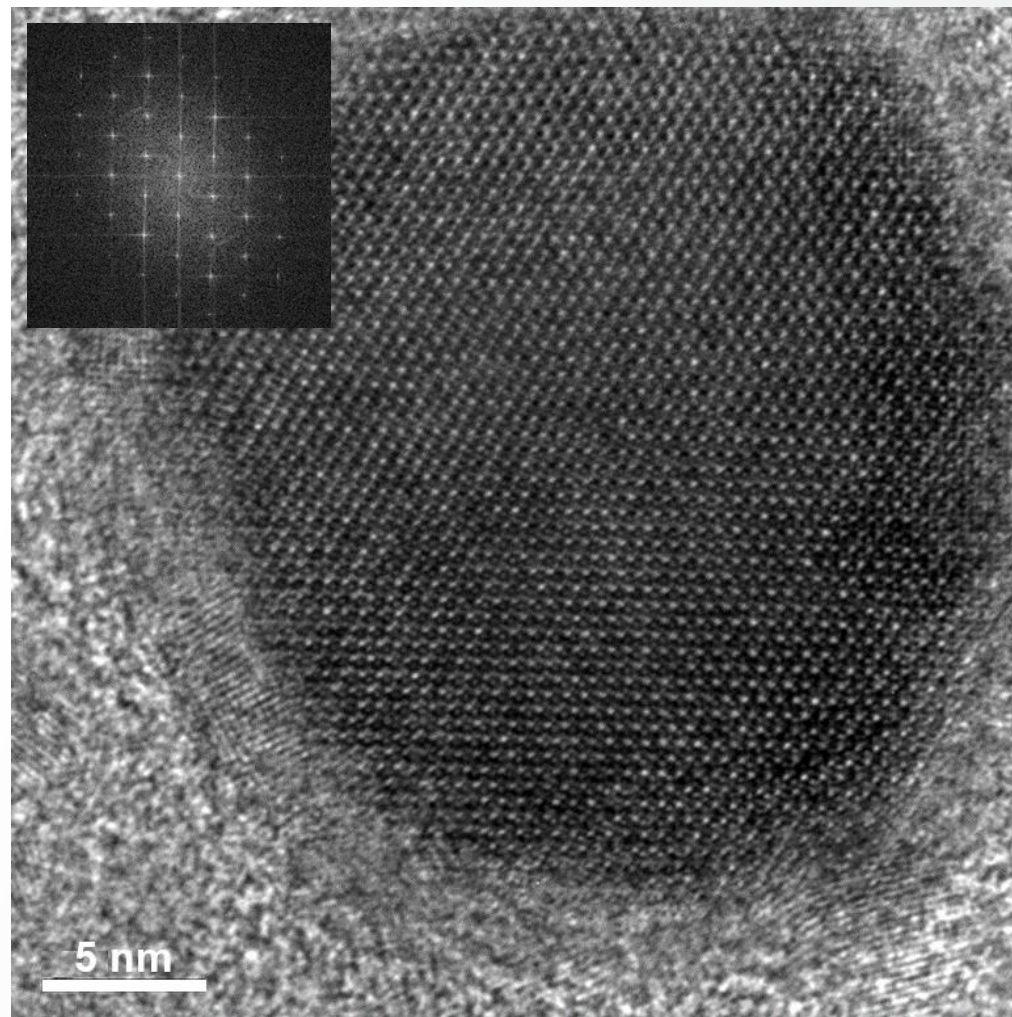
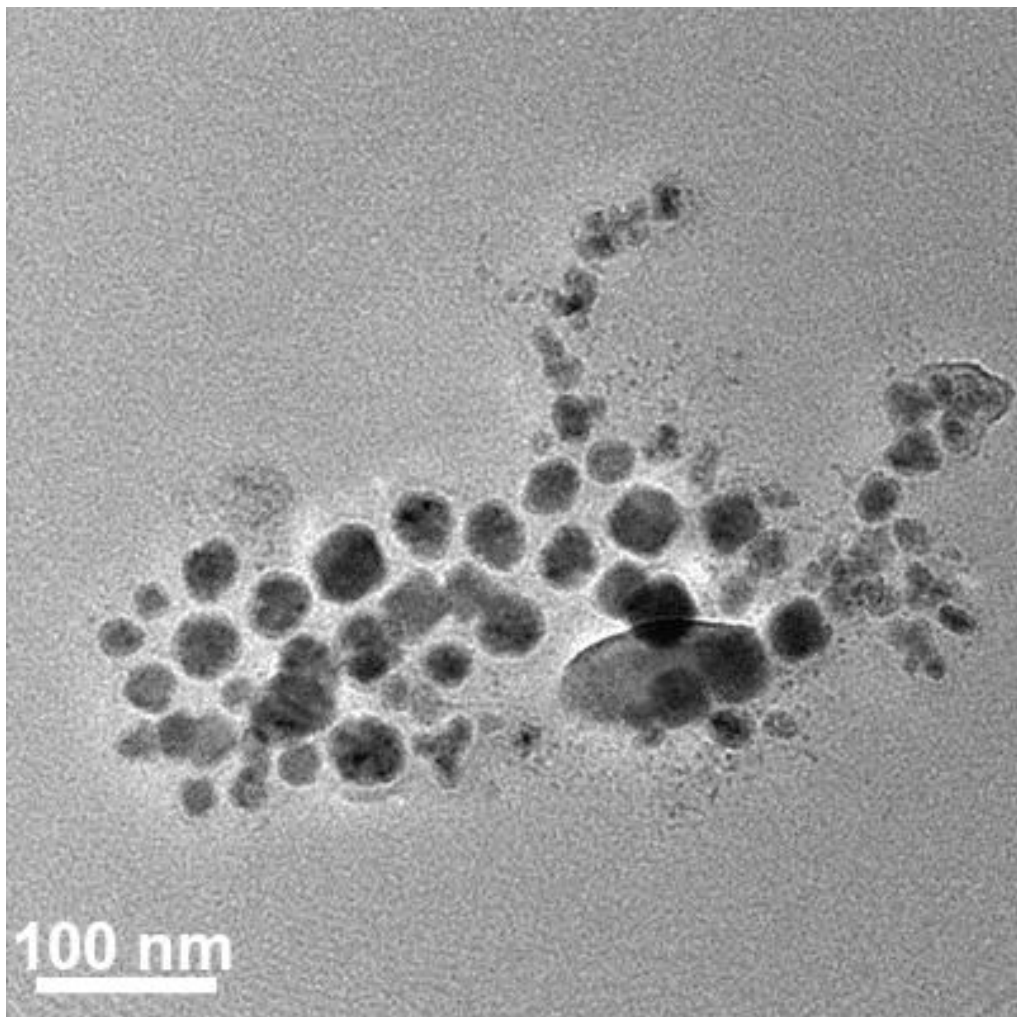
Dislocation on Lattice Images



Illustrations of lattice images that contain easily interpreted information. (A) The spinel/olivine interface; (B) dislocation at a heterojunction between InAsSb and InAs; (C) a grain boundary in Ge faceting on an atomic scale; (D) a profile view of a faceted surface.

Advanced TEM Imaging: High-resolution TEM

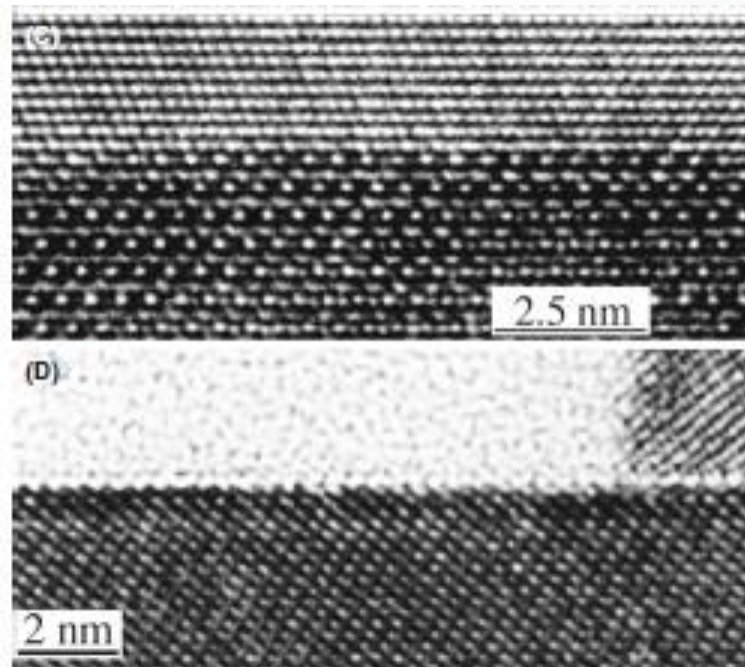
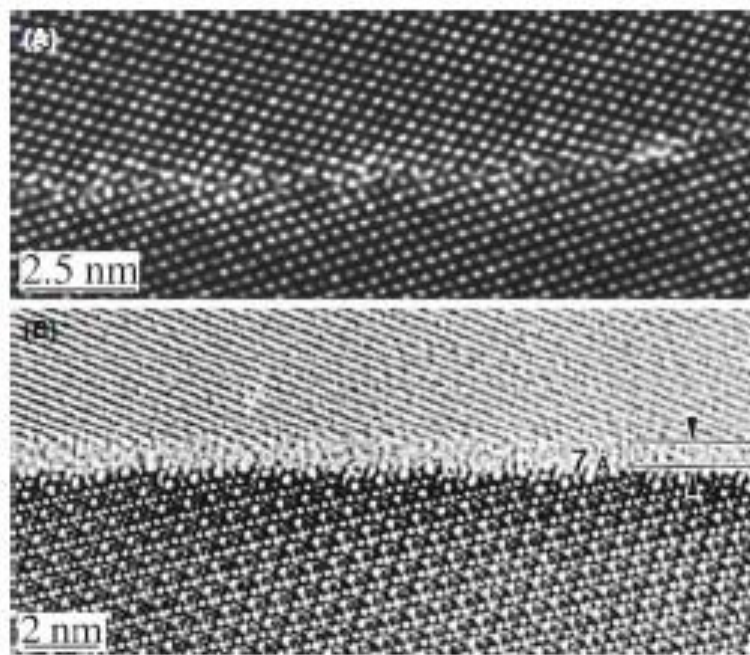
Core-Shell Structure of Nanoparticles



Co/CoO nanoparticles

Advanced TEM Imaging: High-resolution TEM

Planar Interface Investigations

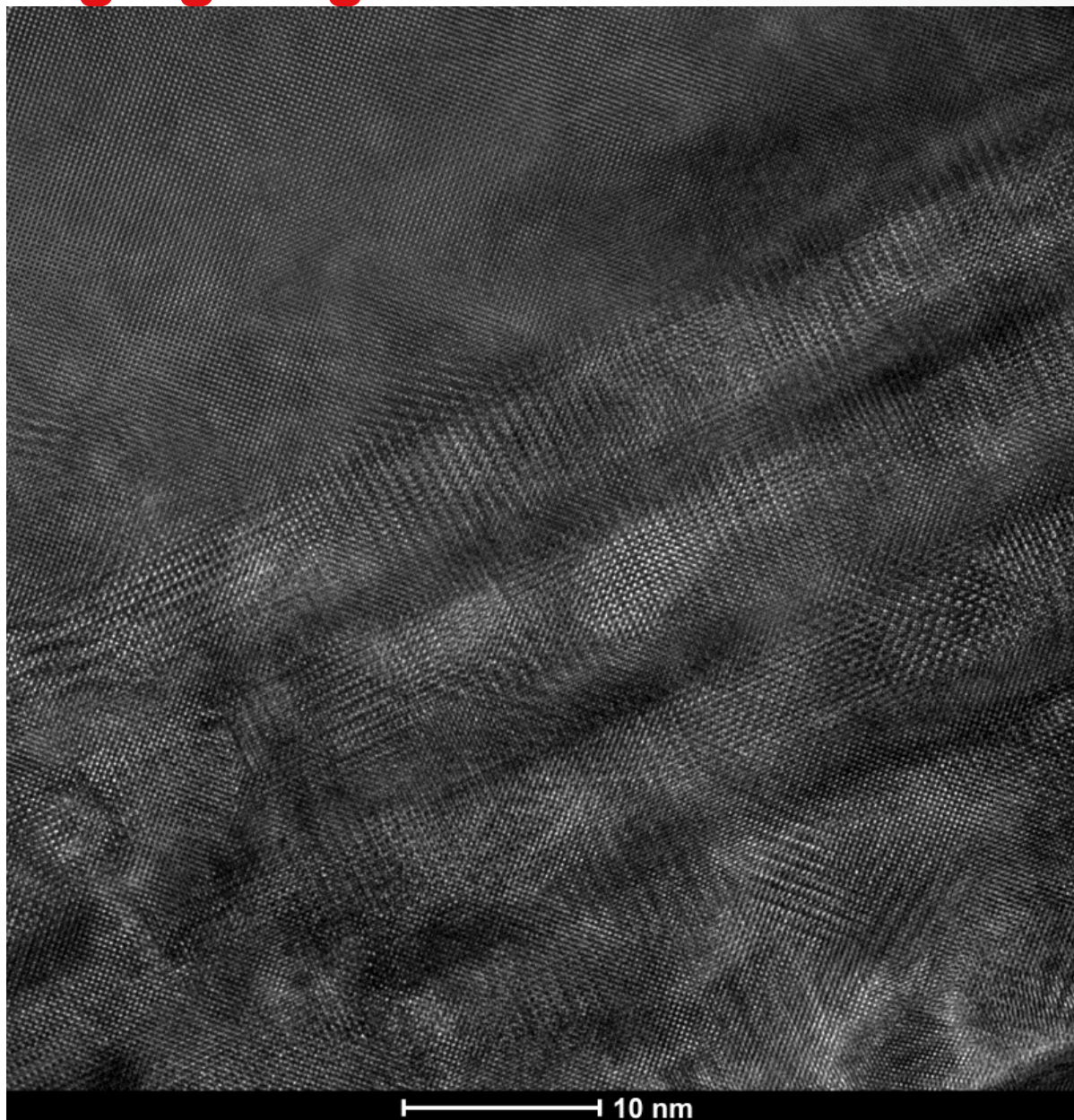


Examples of HRTEM images of planar interfaces.

- (A) Grain boundary in Ge;
- (B) Grain boundary in Si₃N₄ with a layer of glass along the interface
- (C) Phase boundary separating NiO and NiAl₂O₄
- (D) Profile images of the (0001) surface of Fe₂O₃.

Advanced TEM Imaging: High-resolution TEM

Multi Layer SrTiO_3



Transmission Electron Microscopy Webinar Series

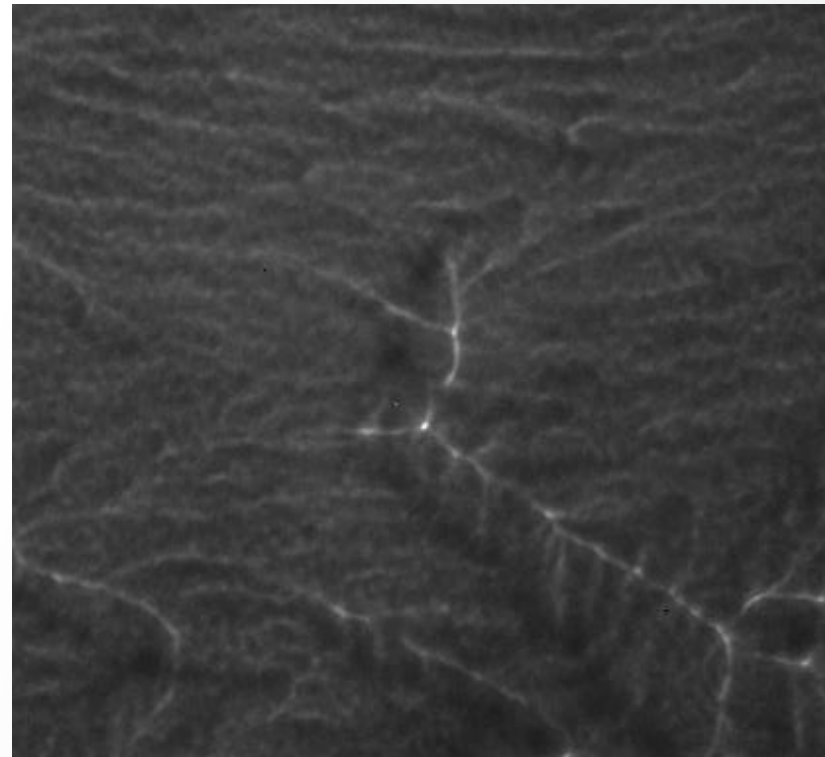
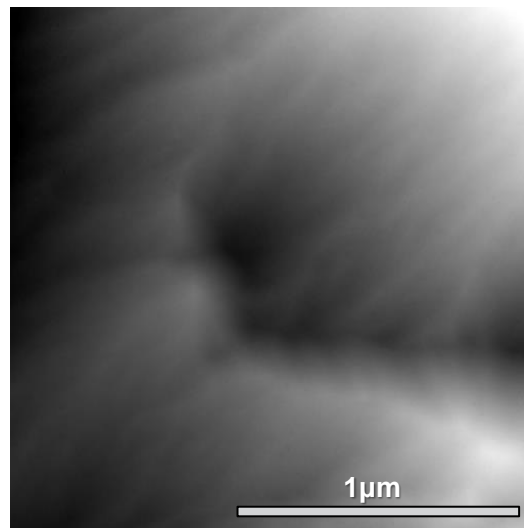
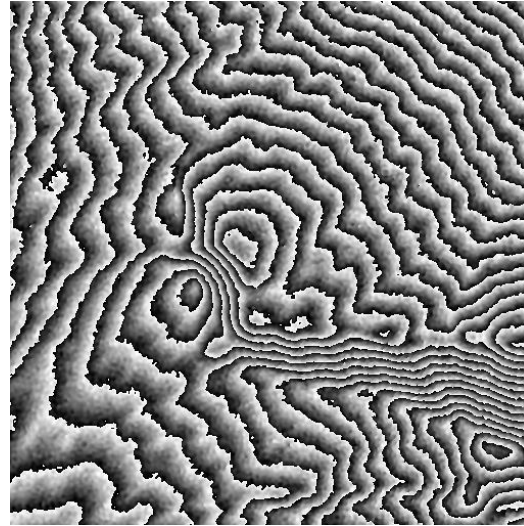
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 - Life-Sciences

Special Investigation Cases

Magnetic Materials

4000 nm

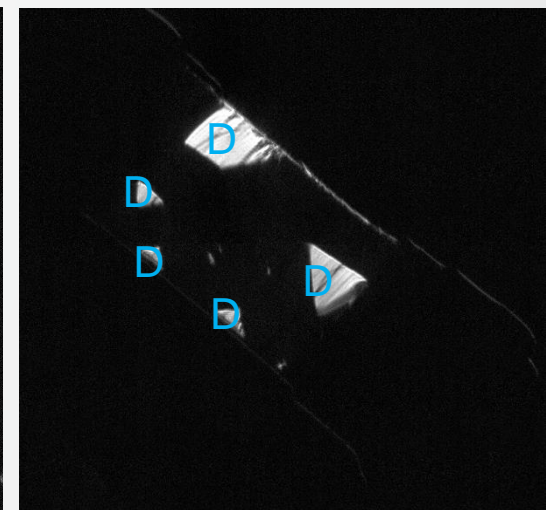
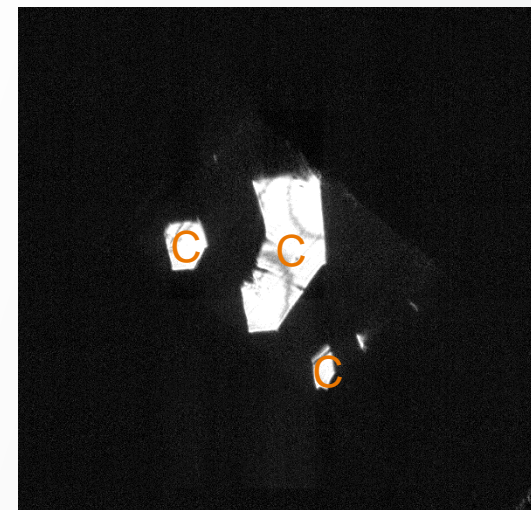
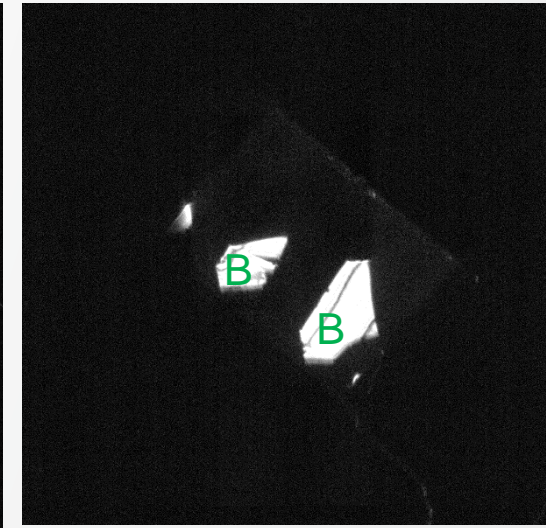
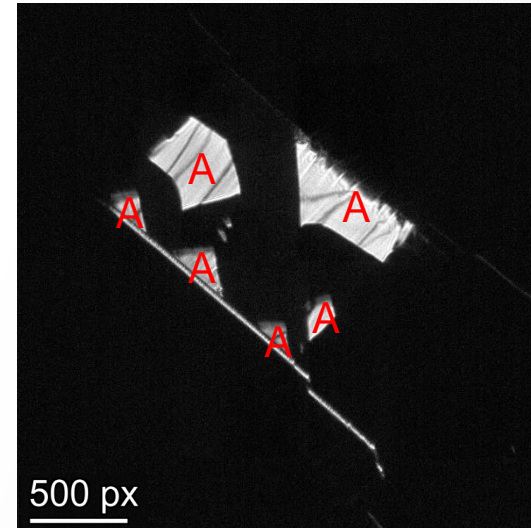
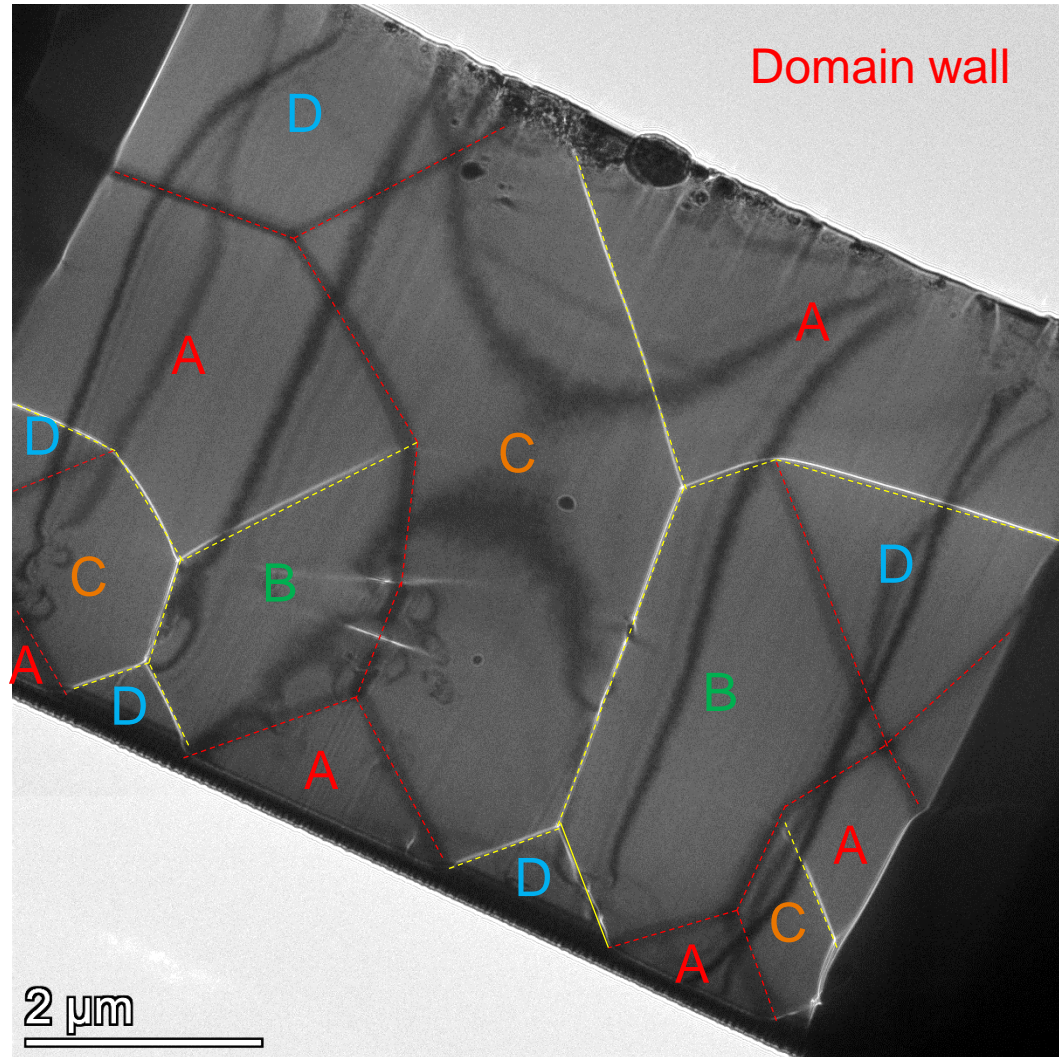


Direct imaging of complex magnetic materials

Sample courtesy: Dr. Andras Kovacs, Forschungszentrum Jülich

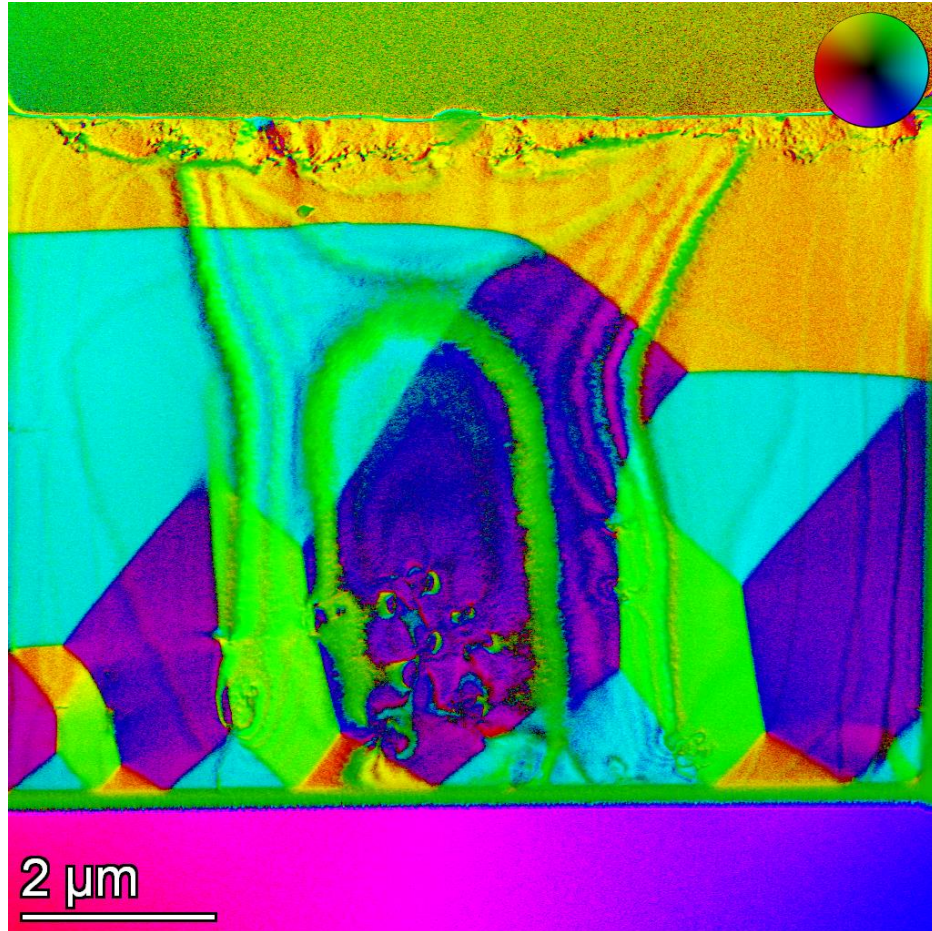
Special Investigation Cases

Magnetic Materials – Lorentz Foucault Imaging

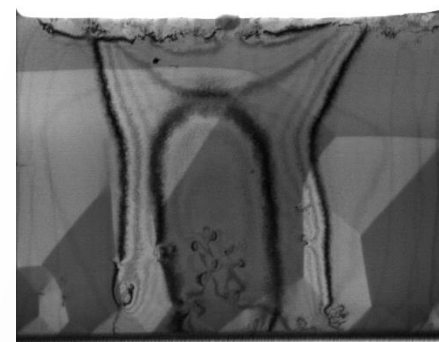


Special Investigation Cases

Magnetic Materials – LM DPC

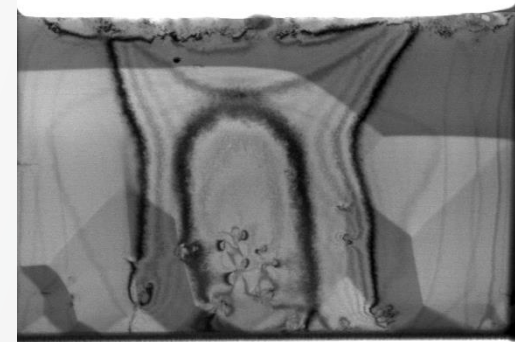


DF_A



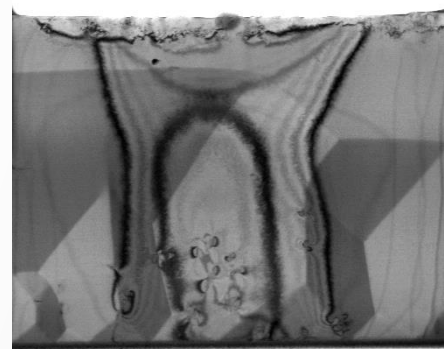
2 μm

DF_B



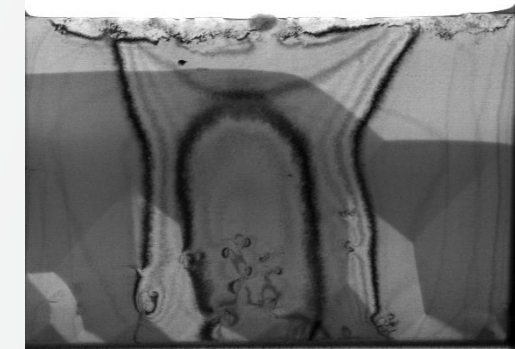
2 μm

DF_C



2 μm

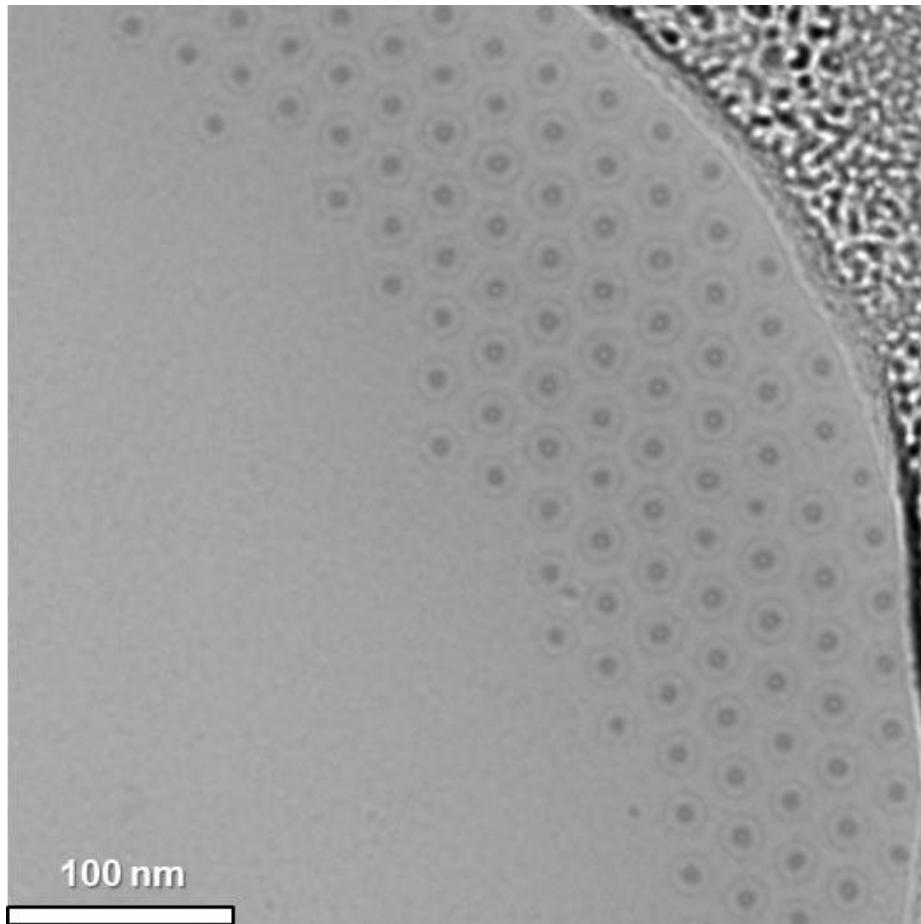
DF_D



2 μm

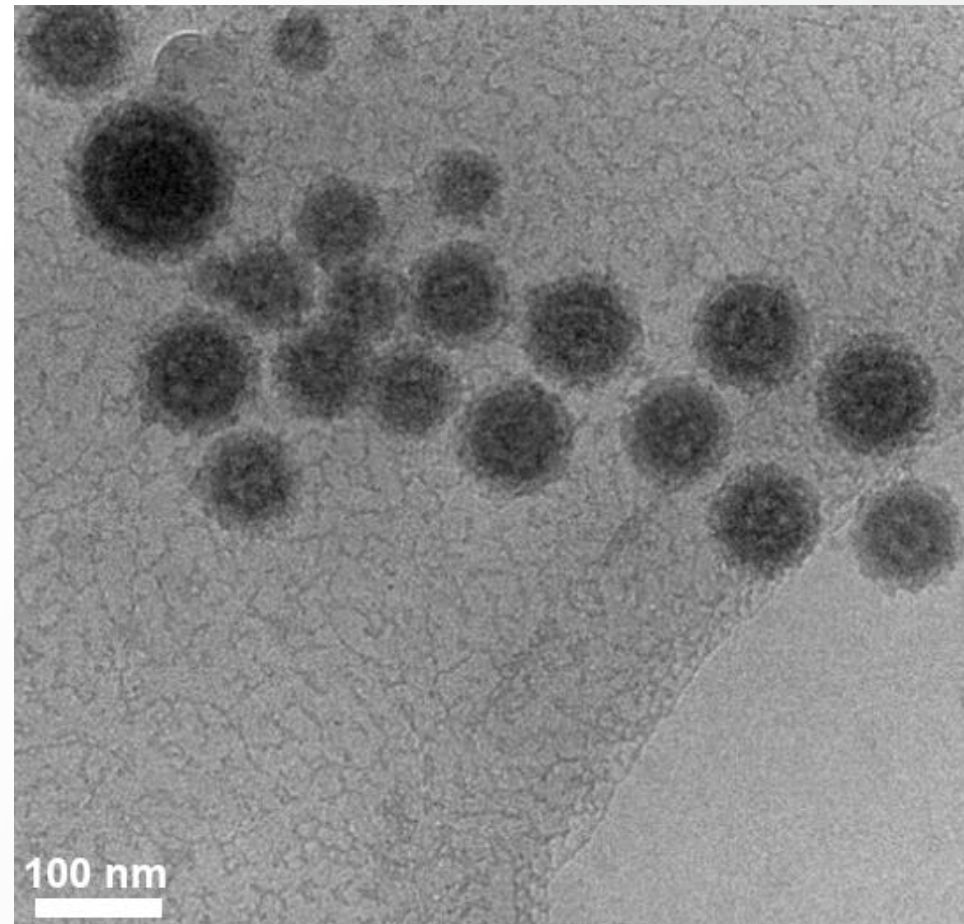
Special Investigation Cases

Soft Materials - Polymer



Block copolymer micelle in water, sphere-sphere packing assembled from blends of PAA-PI-PS and PAA-PS (150/30 nm small spheres)

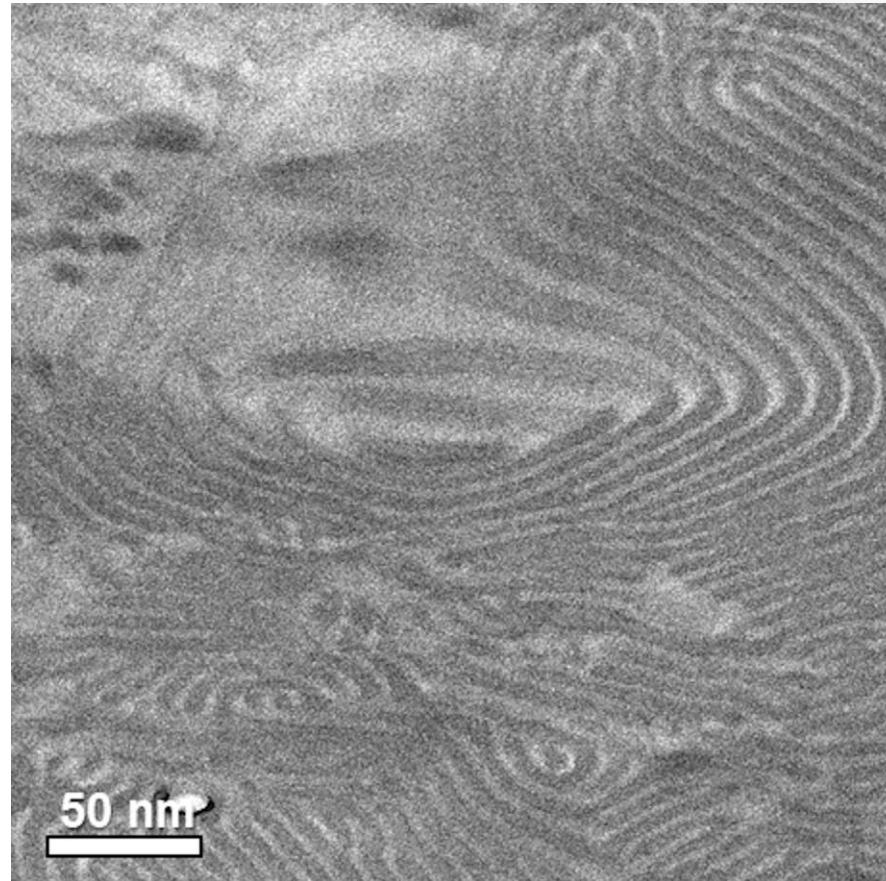
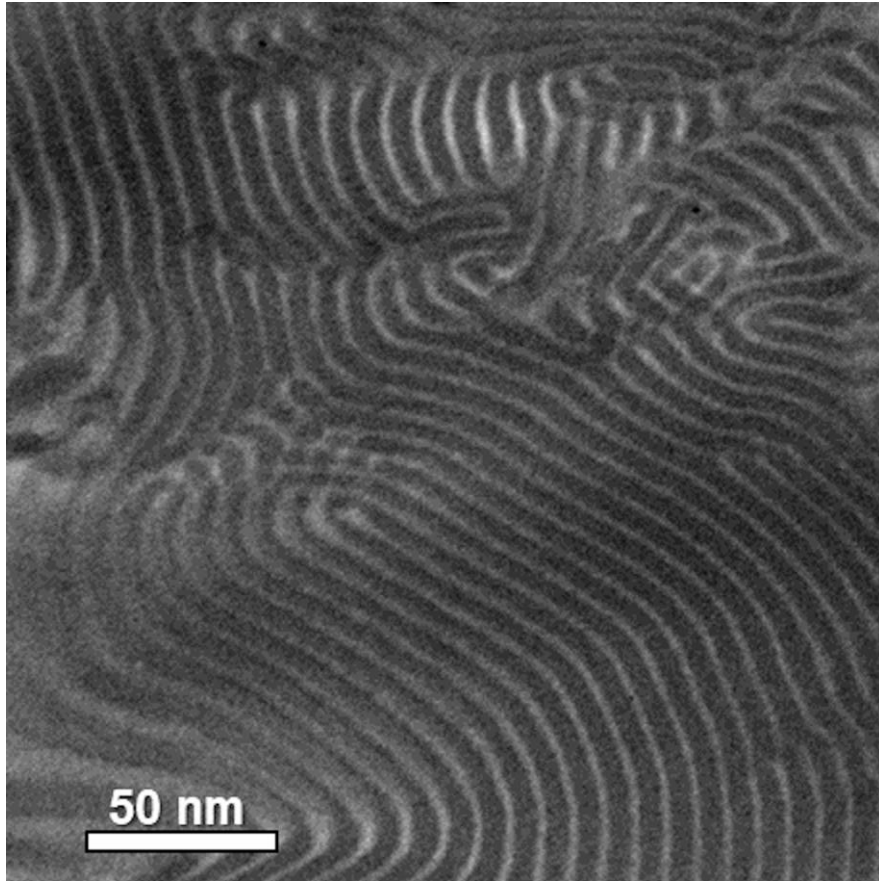
Sample courtesy: Prof. Thomas Epps, III, University of Delaware



Block copolymer giant spherical aggregations in water, with internal phase separation assembled from PPA-PI-PS

Special Investigation Cases

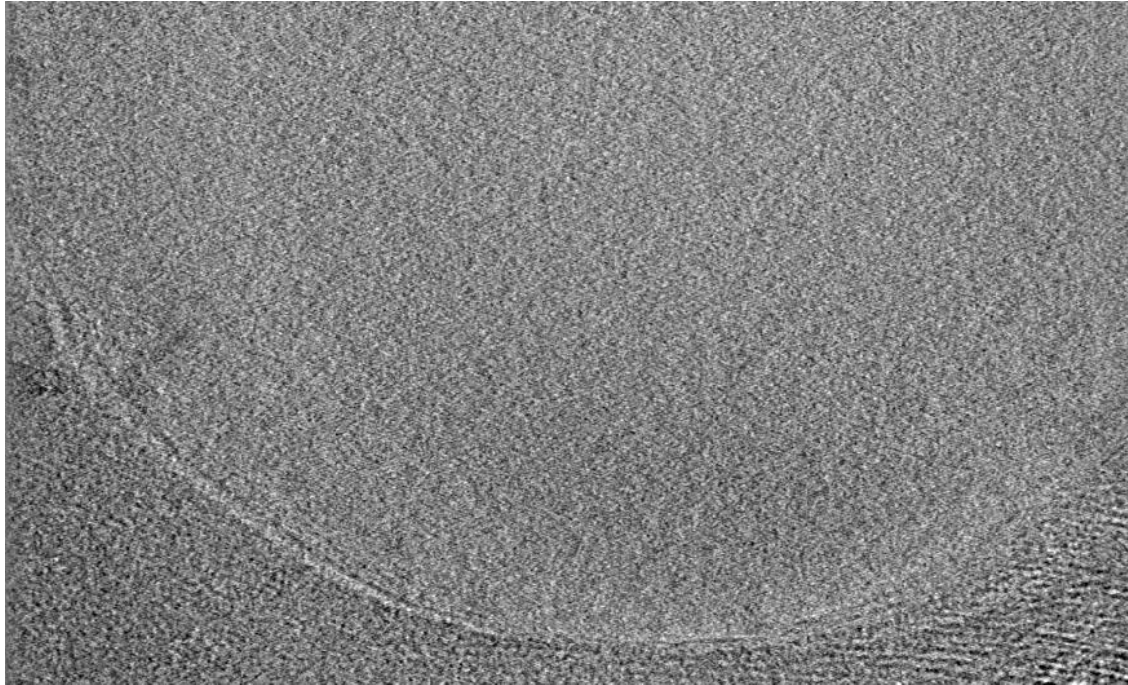
Soft Materials - Polymer



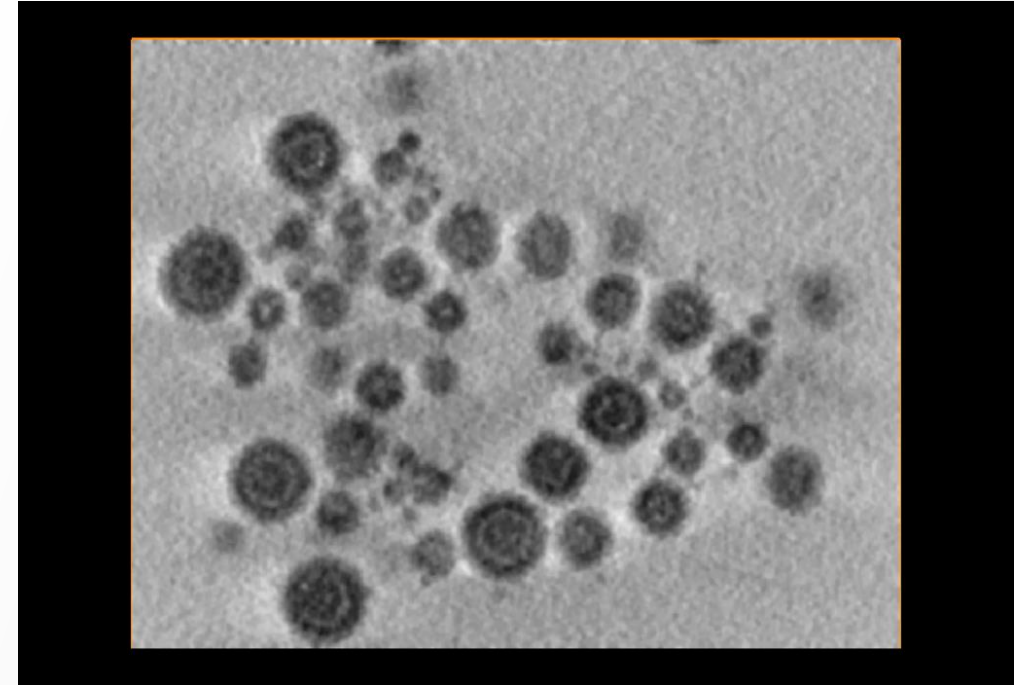
PS-PMMA block copolymer; Lamellar structure with PS units exhibiting light and PMMA units exhibiting dark contrast

Special Investigation Cases

Soft Materials – Polymer with Cryo Tomography



Block copolymer micelle in water, sphere-sphere packing assembled from blends of PAA-PI-PS and PAA-PS (150 & 30 nm spheres).



Block copolymer giant spherical aggregations in water, with internal phase separation assembled from PAA-PI-PS (100 - 200nm spheres)

Special Investigation Cases

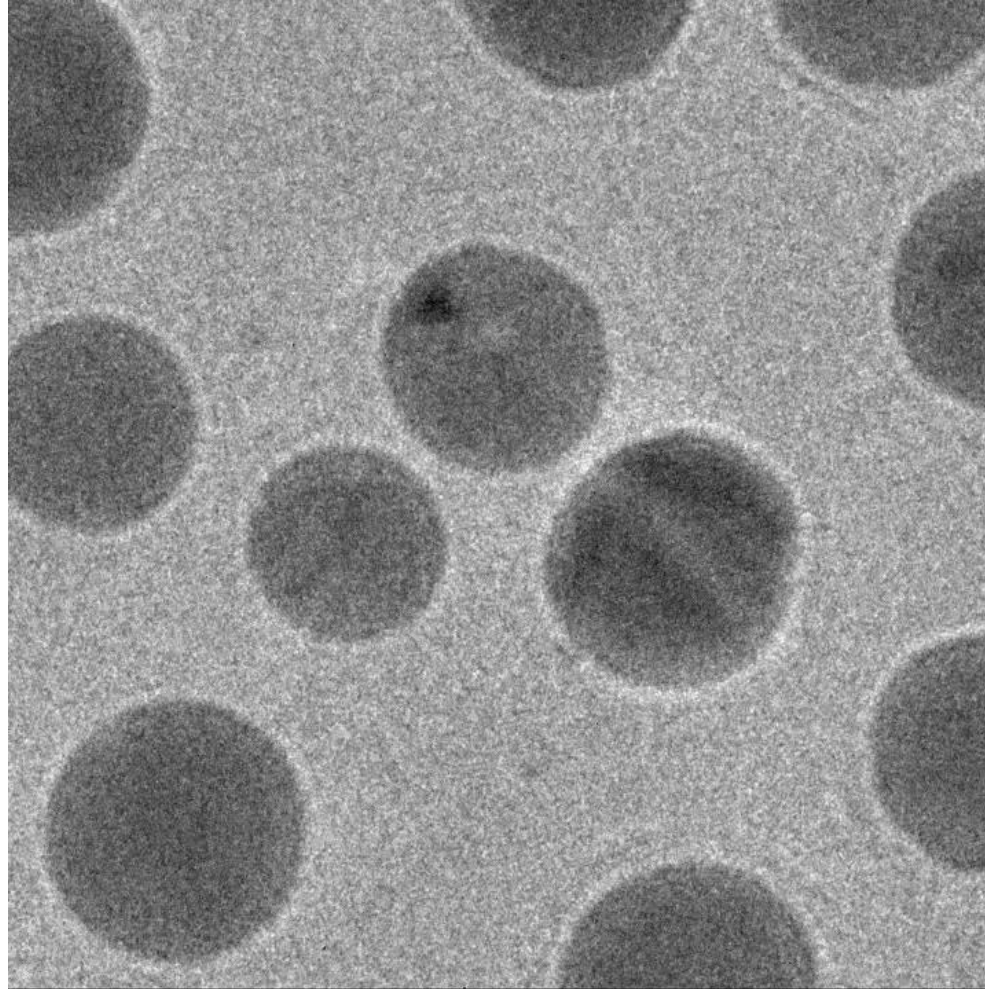
In-situ Experiments



Real time TEM
25 fps

Special Investigation Cases

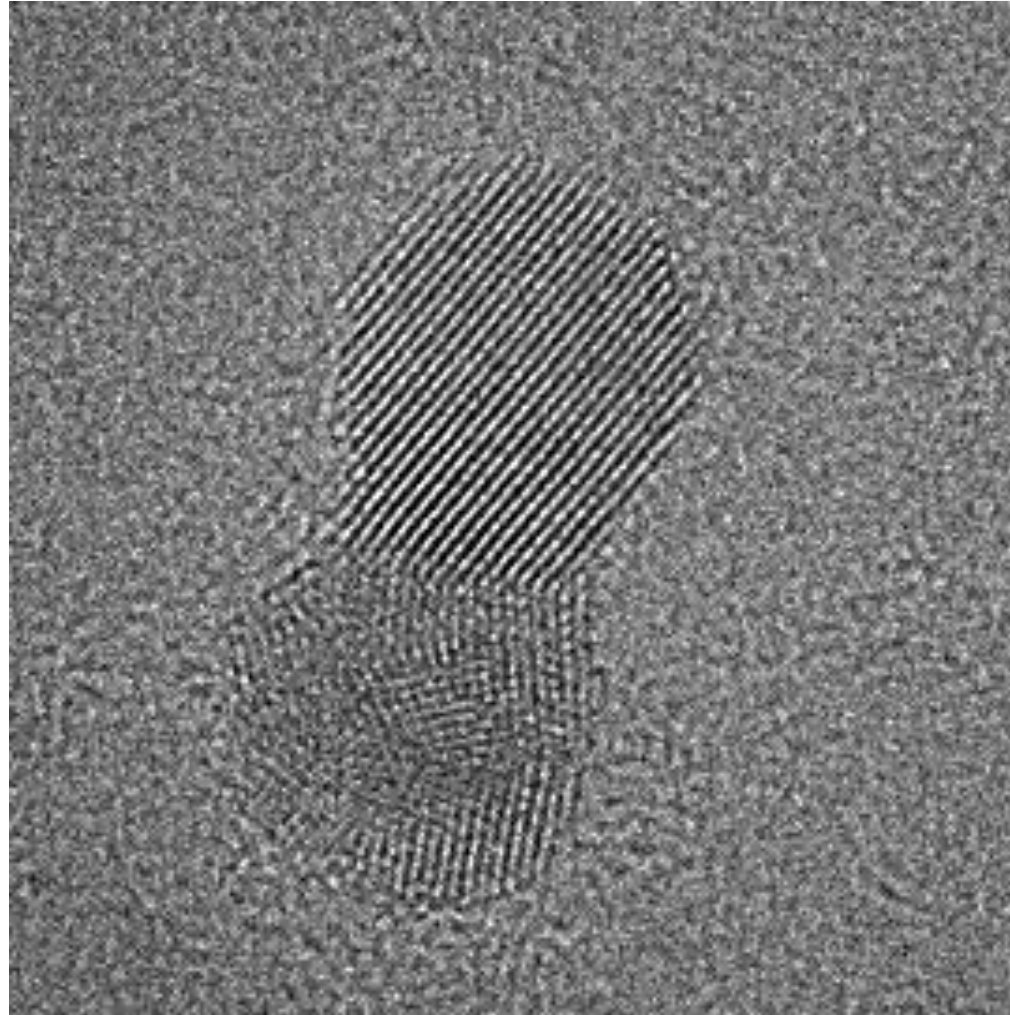
In-situ Experiments



Movie of Au nanoparticles
coalescence @ 900°C
with 30 fps (4k x 4k) - video
running at half speed

Special Investigation Cases

In-situ Experiments

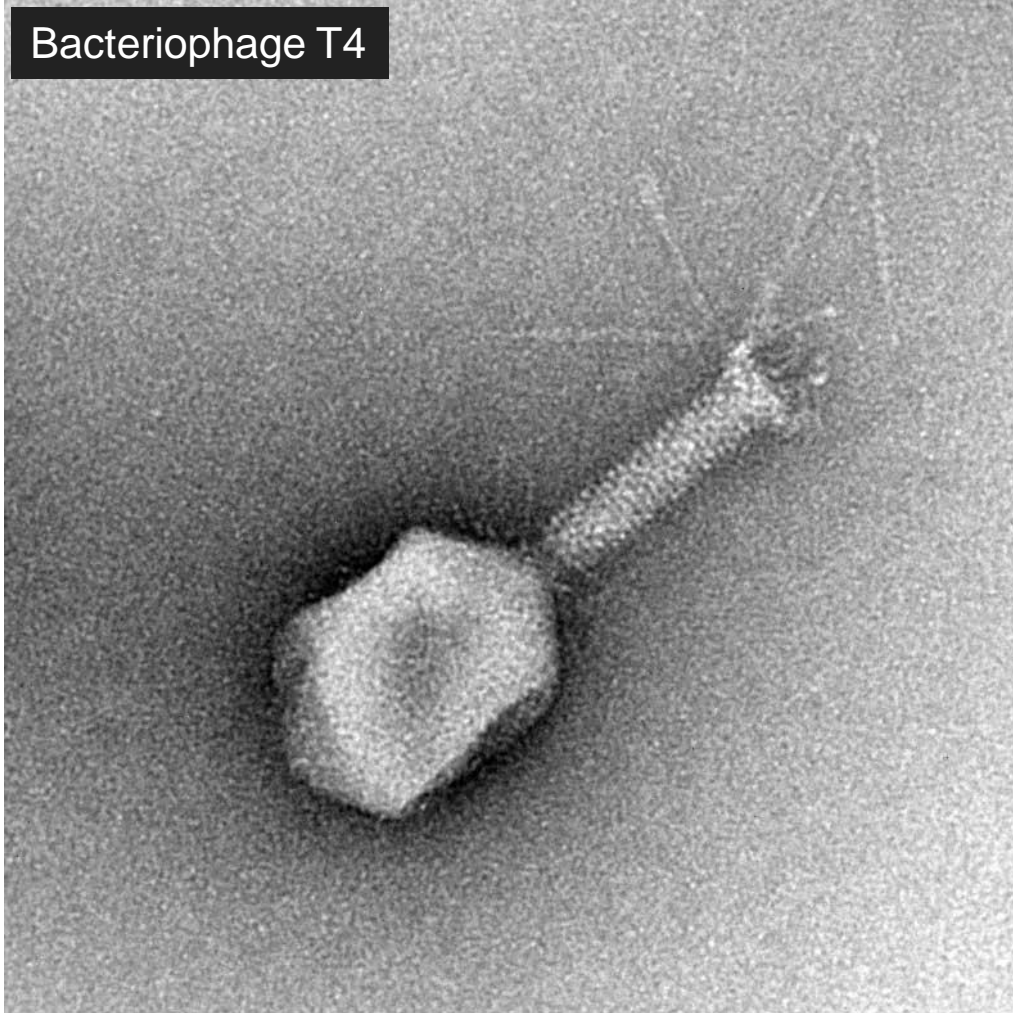


Movie of Au nanoparticles sintering in the beam with 25 fps

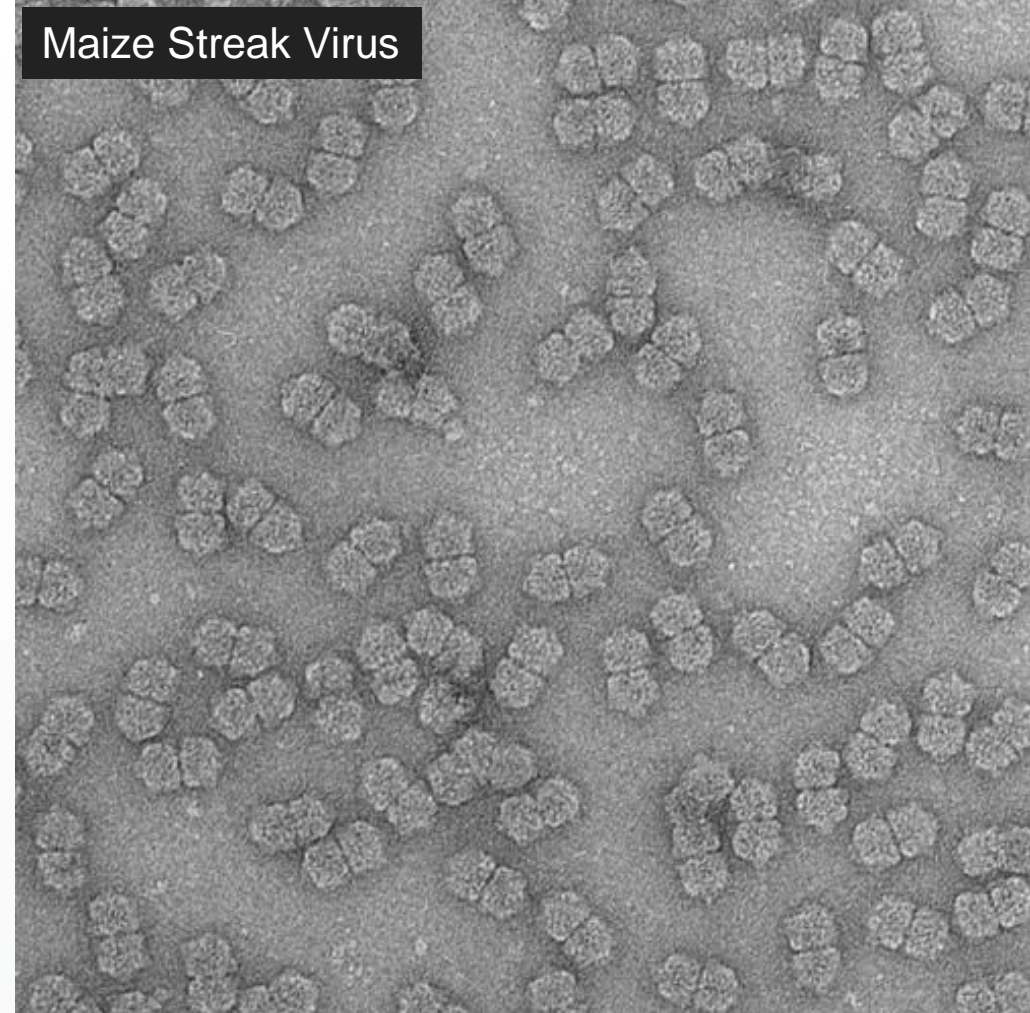
Special Investigation Cases

Application for Life Science – Negative Stain (Room Temperature)

Bacteriophage T4



Maize Streak Virus



Special Investigation Cases

Application for Life Science – Positively Stained Renal Biopsy Section (Room Temperature)

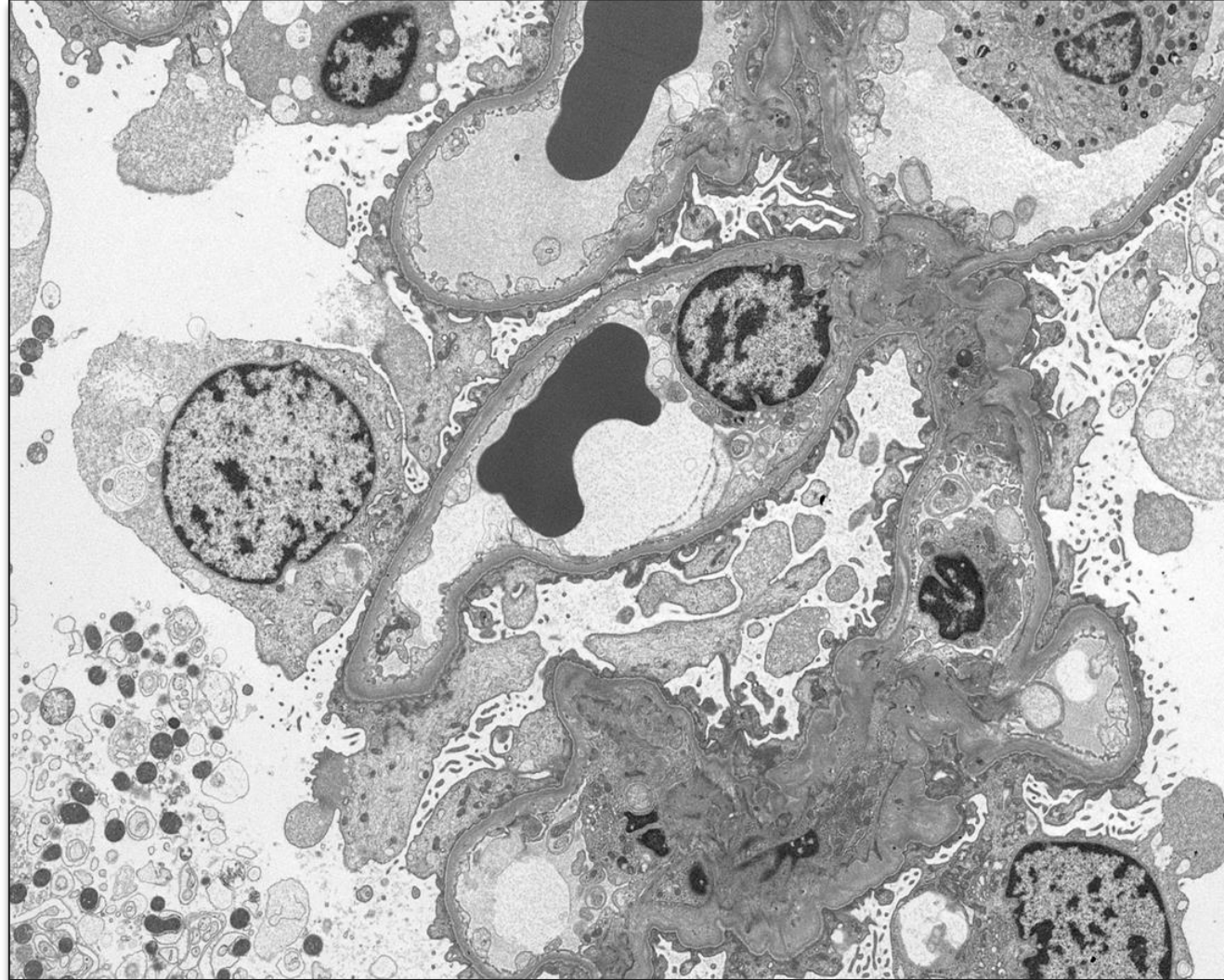


Image courtesy of Dr. Ito, Yorkhill Hospital, Glasgow, UK

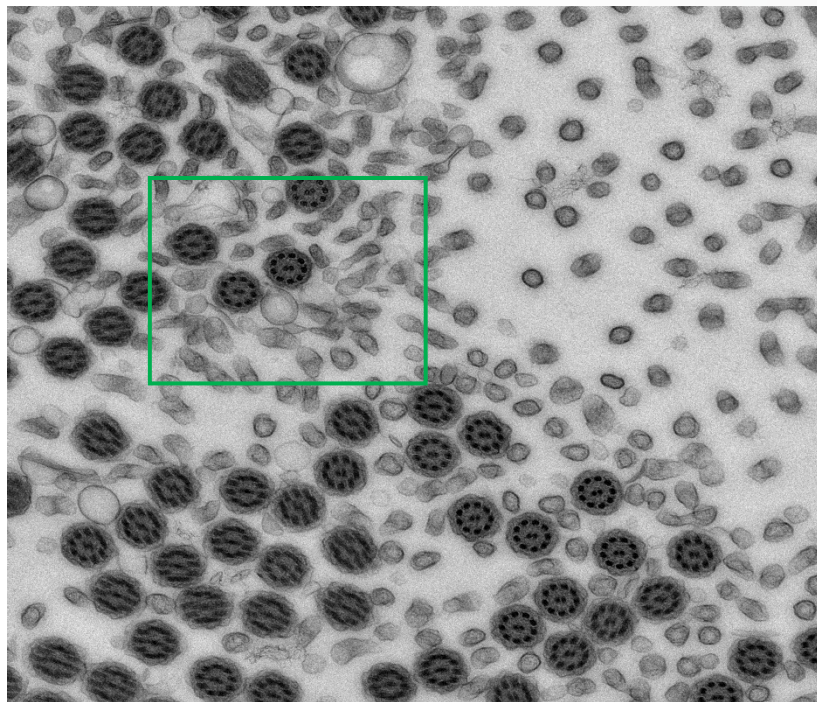
Special Investigation Cases

Application for Life Science – Lung Epithelium (Room Temperature)



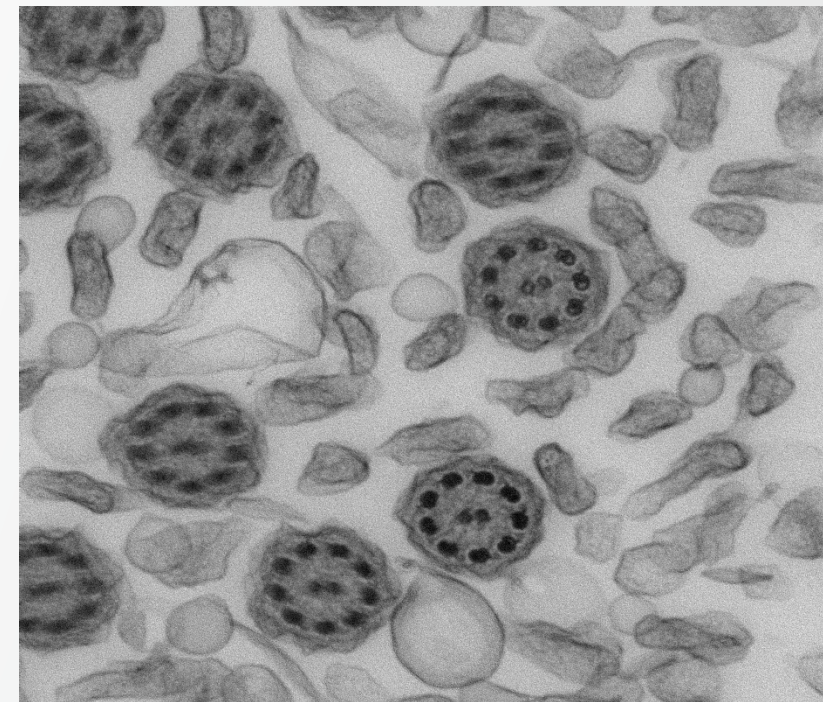
TEM at 120kV

Image size:	4kx4k	Exposure time:	1 s
Detector:	Ceta 16M	Magnification:	1600x
Pixel size:	6.3 nm		



TEM at 120kV

Image size:	4kx4k	Exposure time:	1 s
Detector:	Ceta 16M	Magnification:	3400x
Pixel size:	3.0 nm		

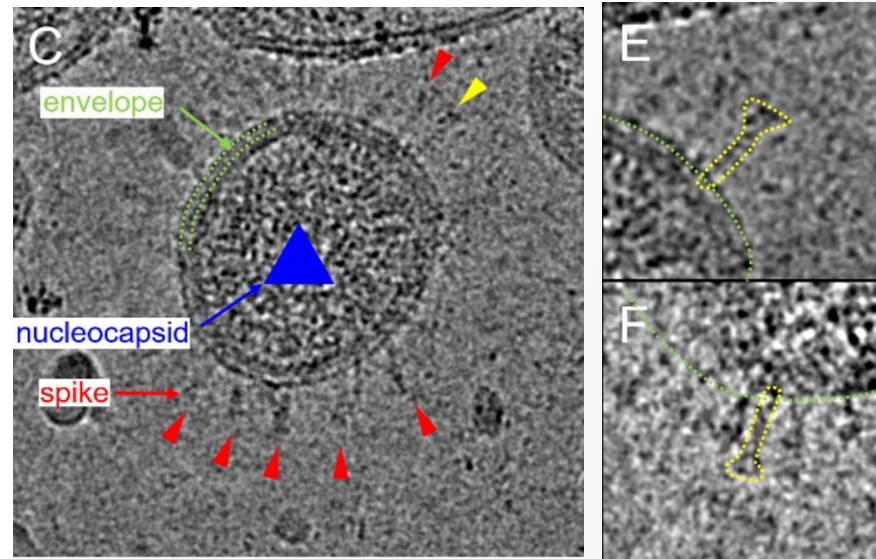
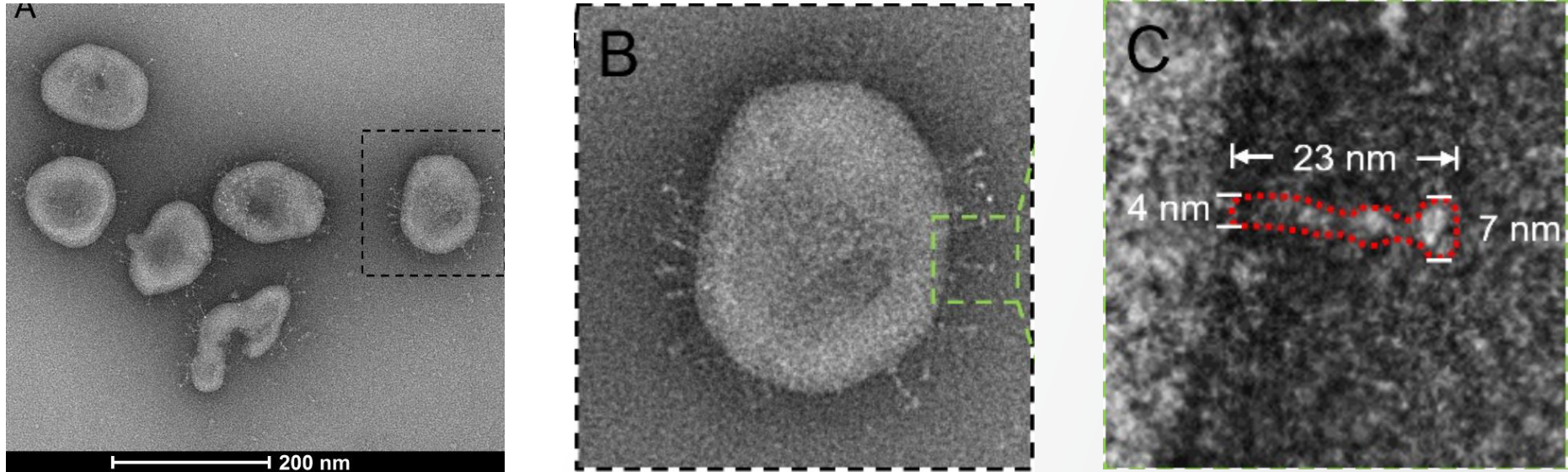


TEM at 120kV

Image size:	4kx4k	Exposure time:	1 s
Detector:	Ceta 16M	Magnification:	28000x
Pixel size:	0.36nm		

Special Investigation Cases

Application for Life Science – Negative stain EM results of SARS-CoV-2.



Negative stain EM results of SARS-CoV-2.

(A). Image of negative stained SARS-CoV-2. Nail-like spikes can be seen.

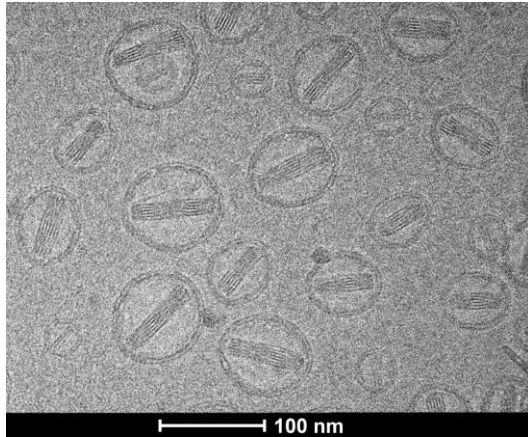
(B). Enlarged view of virion boxed in (A).

(C). Zoom-in view of a spike boxed in (B).

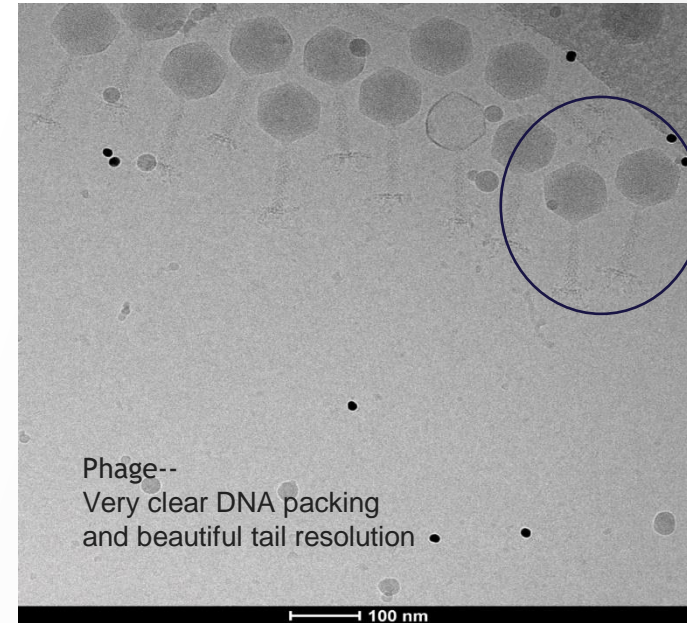
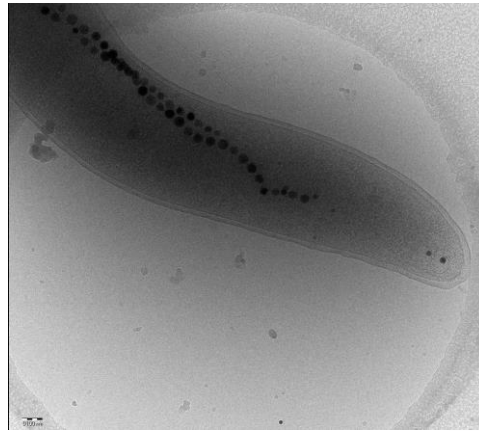
A red dot line depicts the shape. Length, the diameter of the stem, and the spike's head are 23nm, 4nm, and 7nm, respectively.

Special Investigation Cases

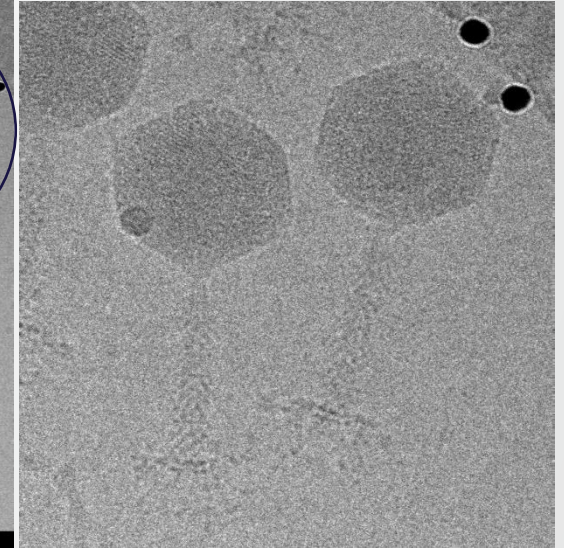
Application for Life Science – Cryogenic Condition



Drug delivery Liposome

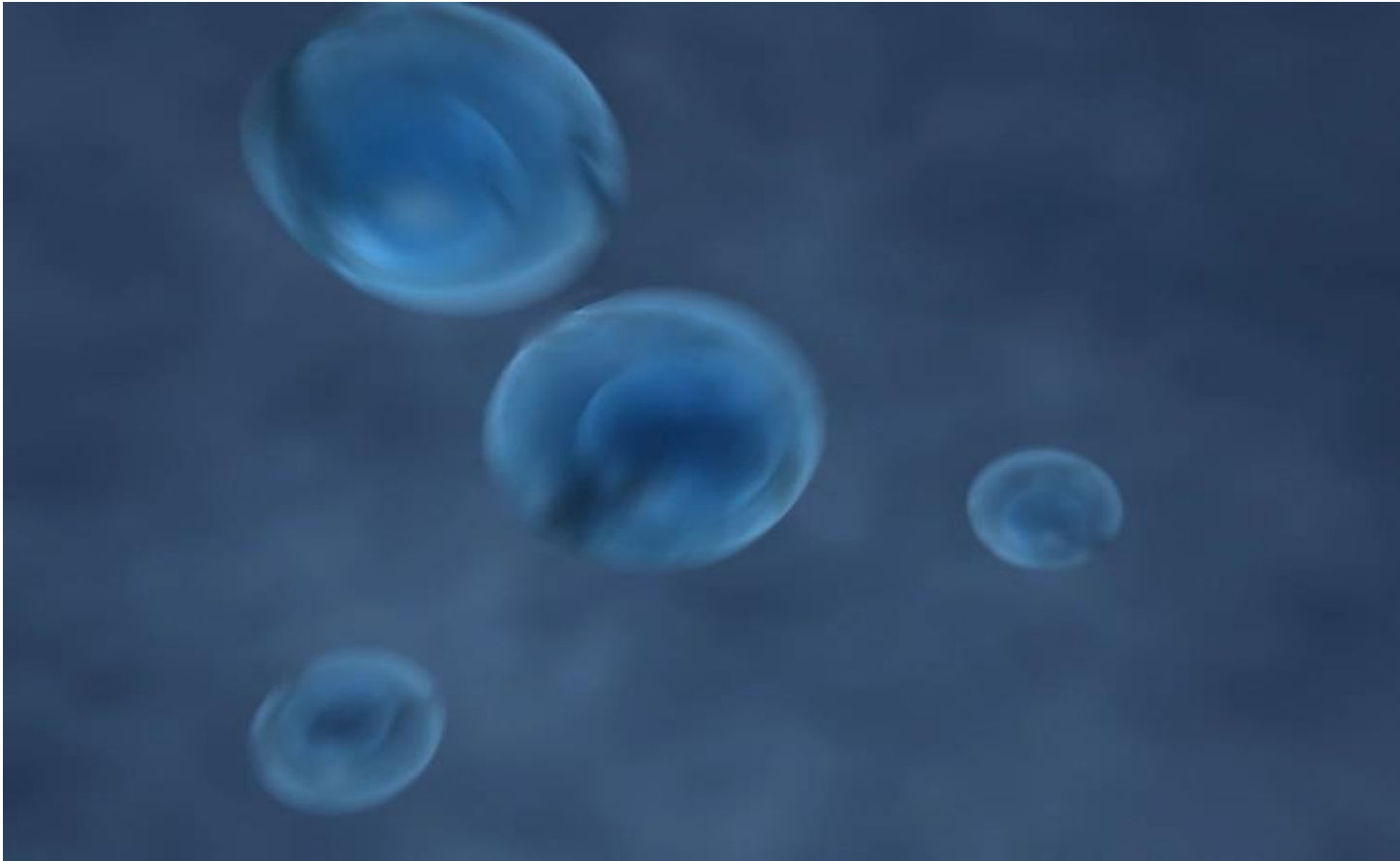


Bacteriophage T4



Special Investigation Cases

Application for Life Science – Cryo Tomography



- Does not rely on labelling or fixation.
- The cells are not fixed, not stained or permeabilized in any way.
- Instead, the sample is preserved in the native state by a very fast freezing technique which is called vitrification
- Provide the context of Cellular environment
- Higher Resolution

Thank you

